

Review of Laser Driven Sources for Multi-Charged Ions

M. Okamura (BNL)
S. Kondrashev (ANL)

High current multi charged heavy ion sources

- Electron cyclotron resonance ion source (ECR)
 - CW operation
 - Well established
- Electron beam ion source (EBIS)
 - Flexible operation
 - High charge states from very heavy species
- Laser ion source (LIS)
 - Powerful pulse current
 - Simple structure

High current multi charged heavy ion sources

- Laser ion source (LIS)
 - Backward ablation
 - Forward emission
 - Selective ionization

High current multi charged heavy ion sources

- Laser ion source (LIS)

1969 First idea was proposed by Byckovsky, Peacock and Pease.

1977 JINR Dubna Cr^{13+} (Synchrophasotron)

1988 Technical University of Munich, ITEP (Van de Graaff)

1994 GSI, ITEP Ta^{10+} (RFQ)

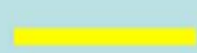
2000 ITEP C^{4+} (Synchrotron)

Production of laser plasma

Sorry - animations cannot be displayed in PDF files



Expanding plasma

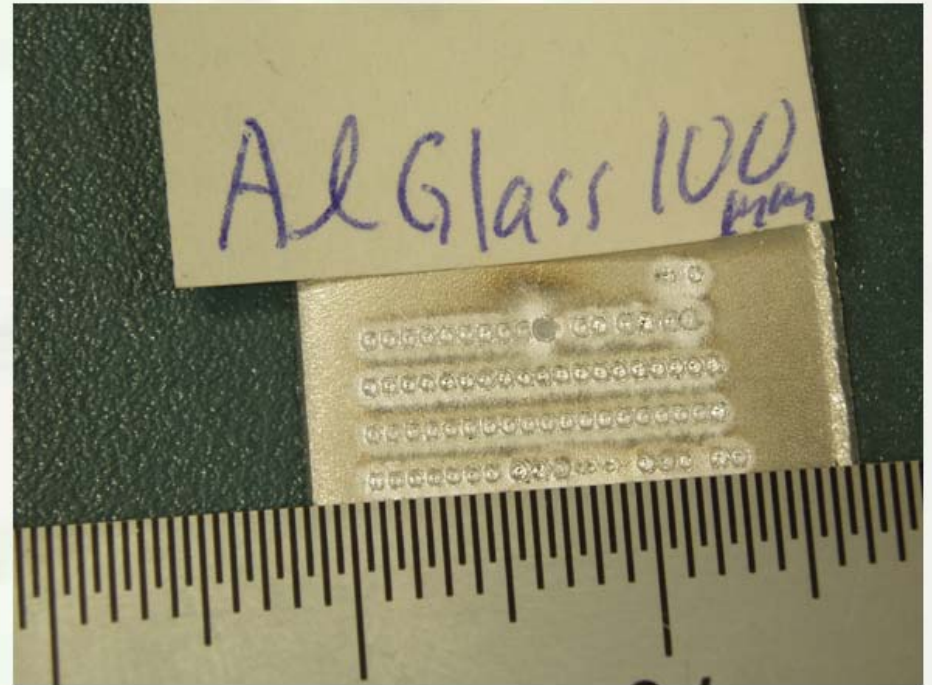


Laser light

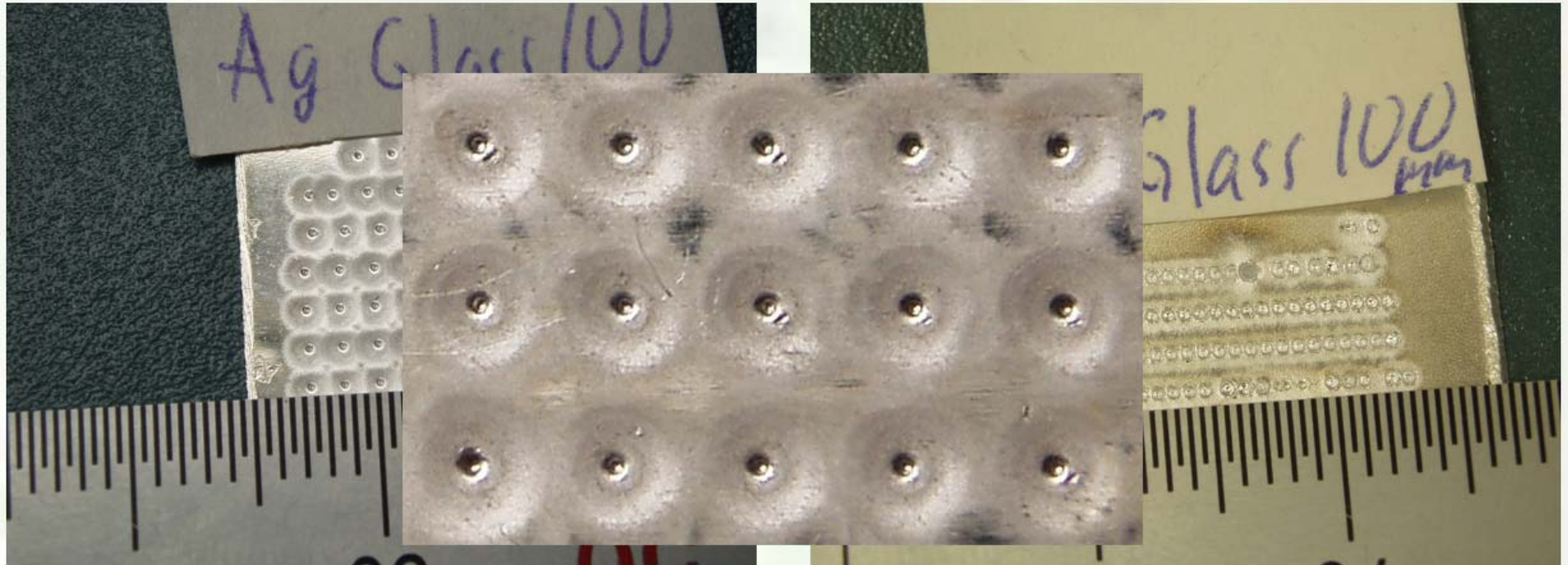
Features of laser plasma

- Very high density plasma induced from a **SOLID** target.
- Plasma expands from the target.
- Initial velocity of the plasma expansion depends on laser power density. (Ions have initial velocity, about 100 eV/u)
- Total amount of ions depends on laser power.
- Charge state distribution depends on laser power density.
(High power density \longrightarrow Highly charged states)

Solid targets



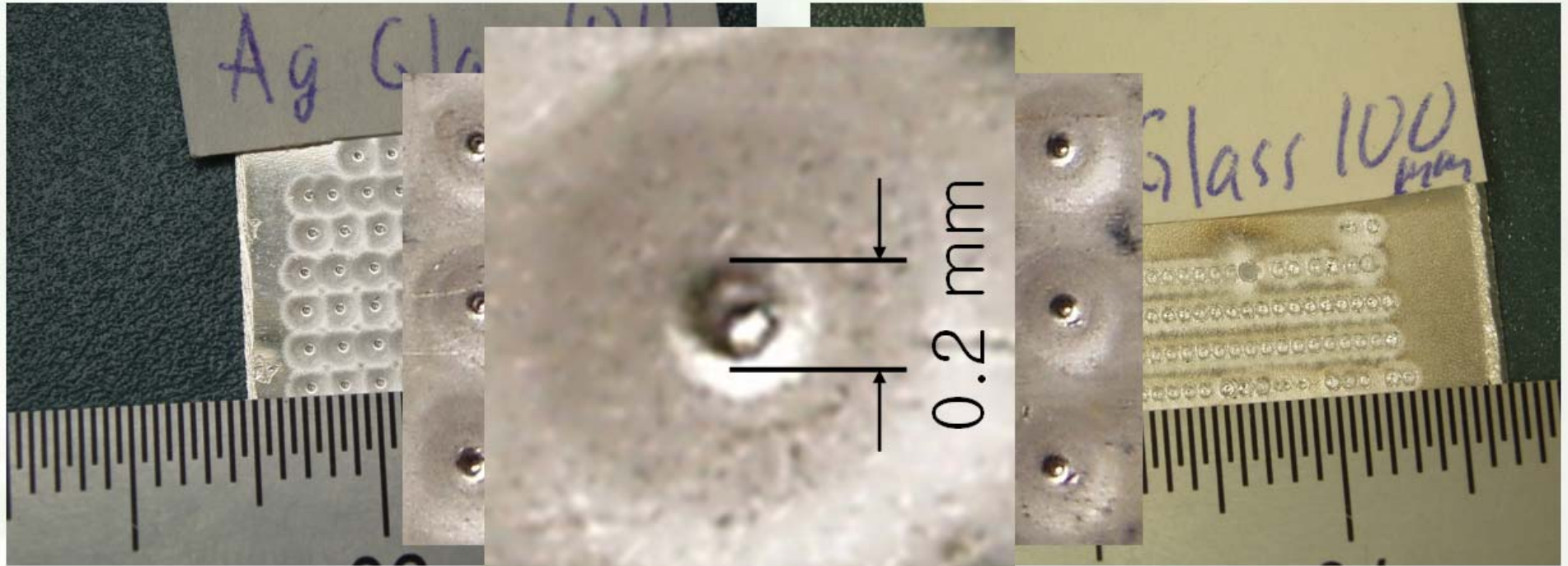
Solid targets



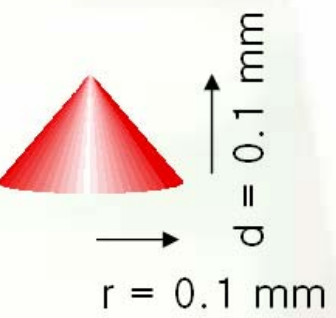
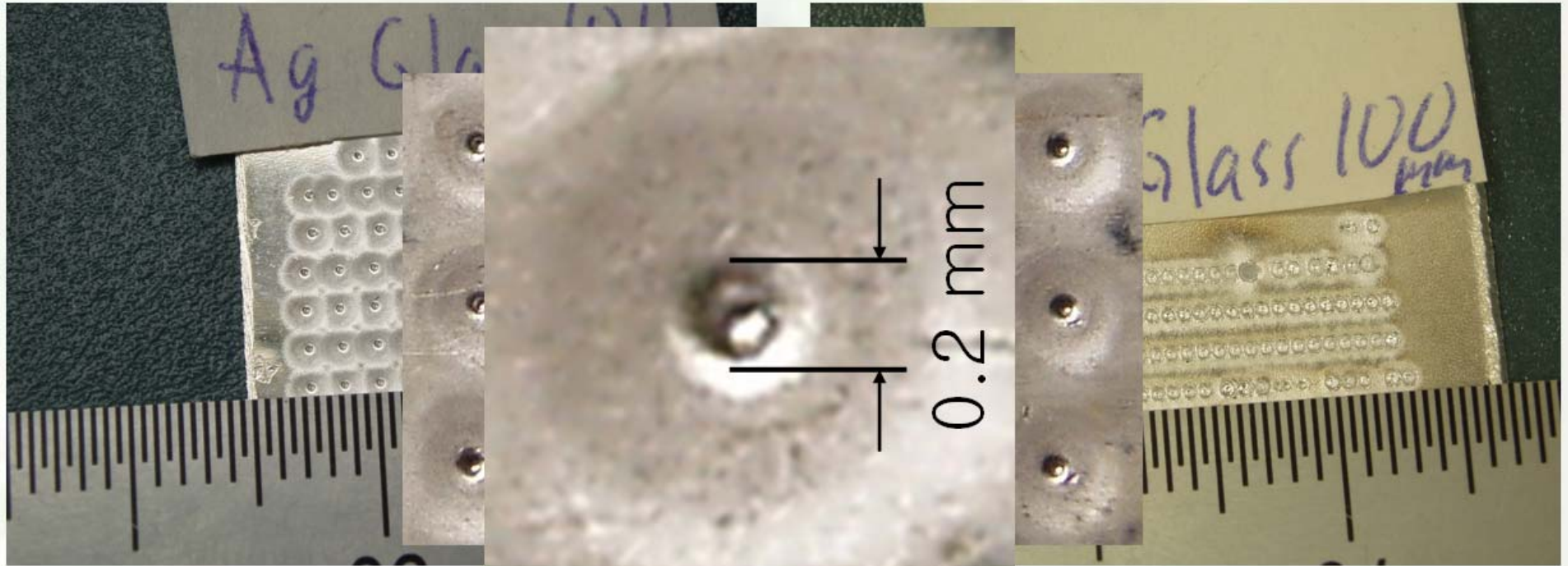
Solid targets



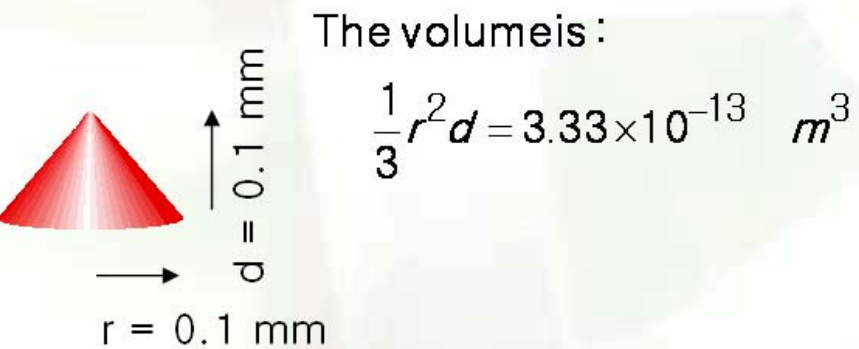
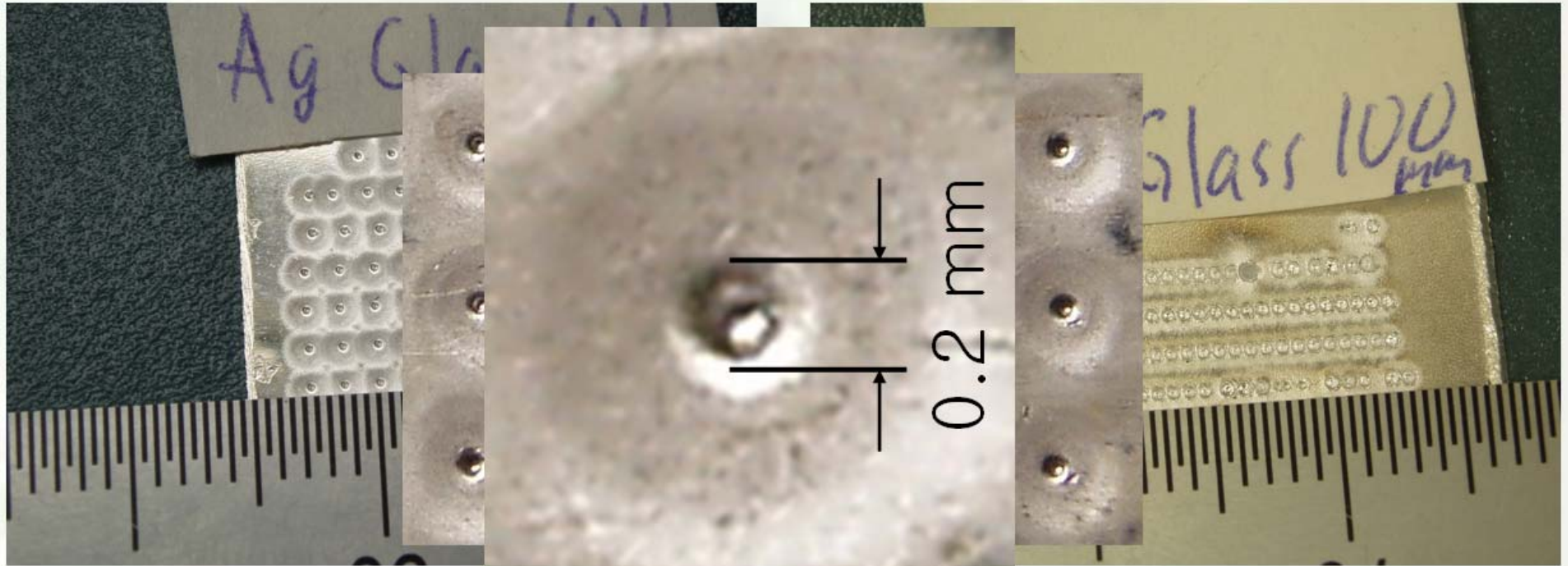
Solid targets



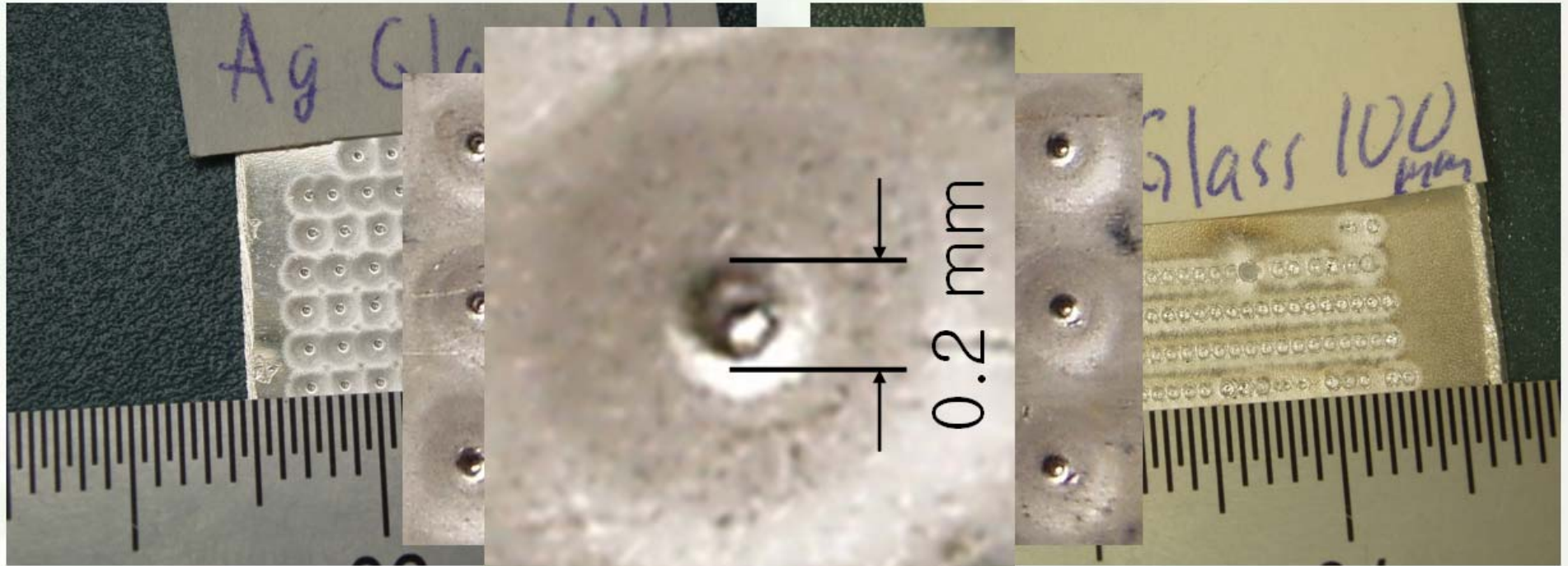
Solid targets



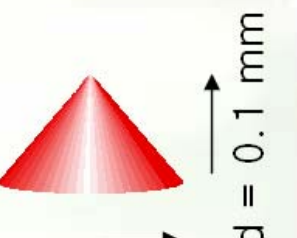
Solid targets



Solid targets



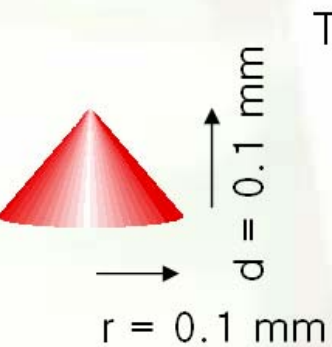
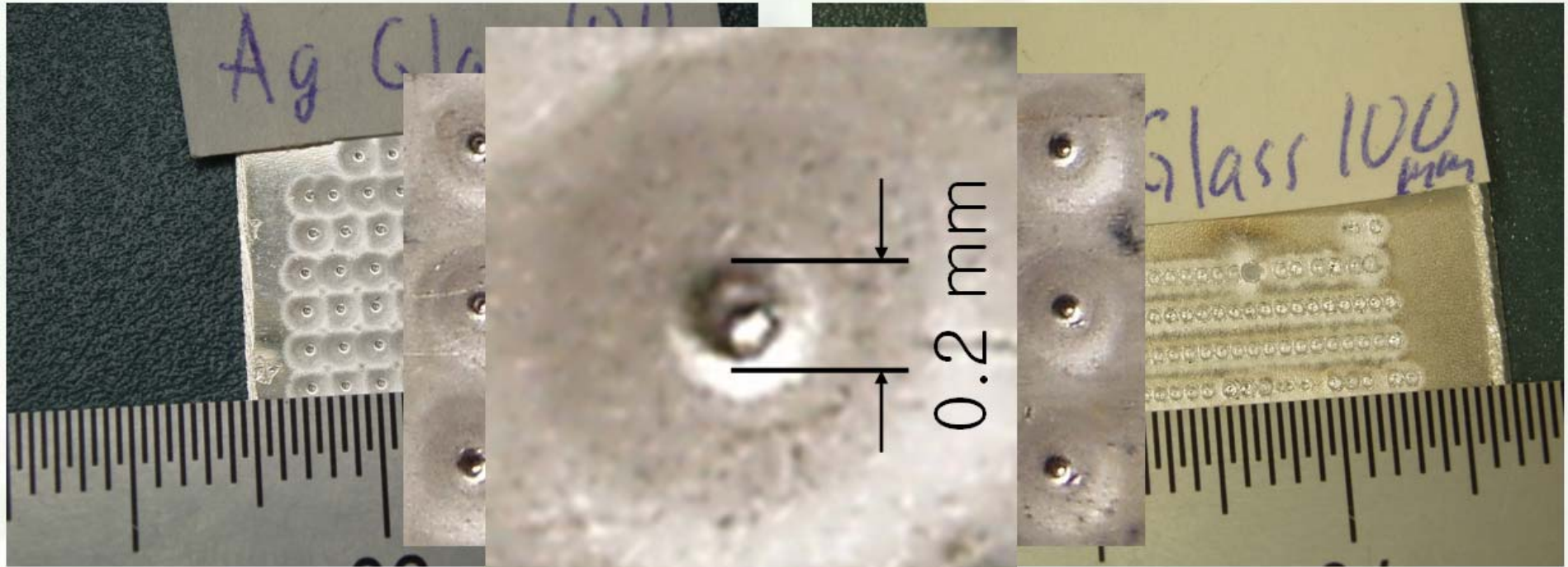
The volume is:



$\frac{1}{3}r^2d = 3.33 \times 10^{-13} \text{ m}^3$

Assuming an Aluminum target,
the density is about 2.7 g/cm^3 ,
and the volume contains;
 2.0×10^{16} ions.

Solid targets



The volume is:

$$\frac{1}{3} r^2 d = 3.33 \times 10^{-13} \text{ m}^3$$

Assuming an Aluminum target,

the density is about 2.7 g/cm^3 ,

and the volume contains;

$$2.0 \times 10^{16} \text{ ions.}$$

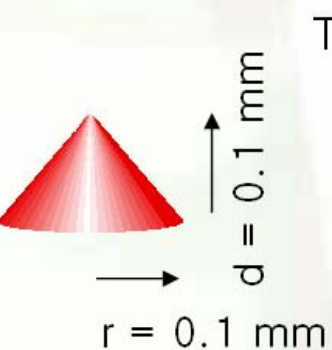
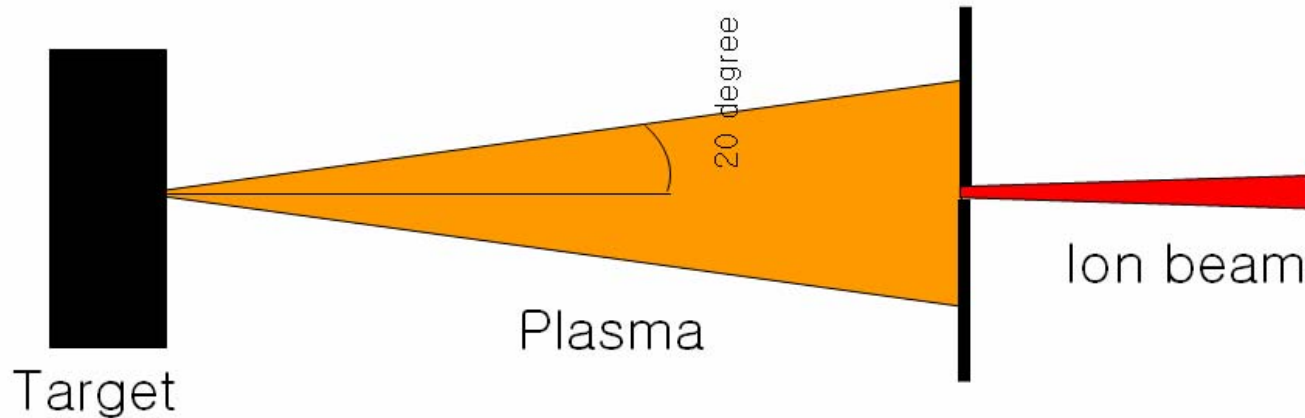
If we get $1 \mu\text{s}$ pulse with charge state $10+$ beam,

$$6.02 \times 10^{23} \times \frac{2700 \times \frac{1}{3} r^2 d}{27/1000} \times \frac{10 \times 1.60 \times 10^{-19}}{10^{-6}} = 32200 \text{ A}$$

Probably only 1% are ionized.

Roughly 320 A beam is produced.

Solid targets



The volume is:

$$\frac{1}{3} r^2 d = 3.33 \times 10^{-13} \text{ m}^3$$

Assuming an Aluminum target,

the density is about 2.7 g/cm^3 ,

and the volume contains;

$$2.0 \times 10^{16} \text{ ions.}$$

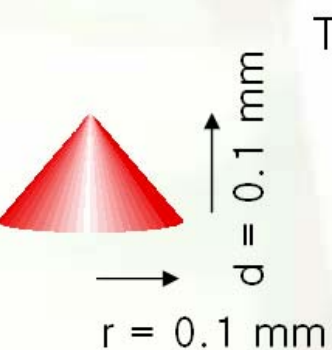
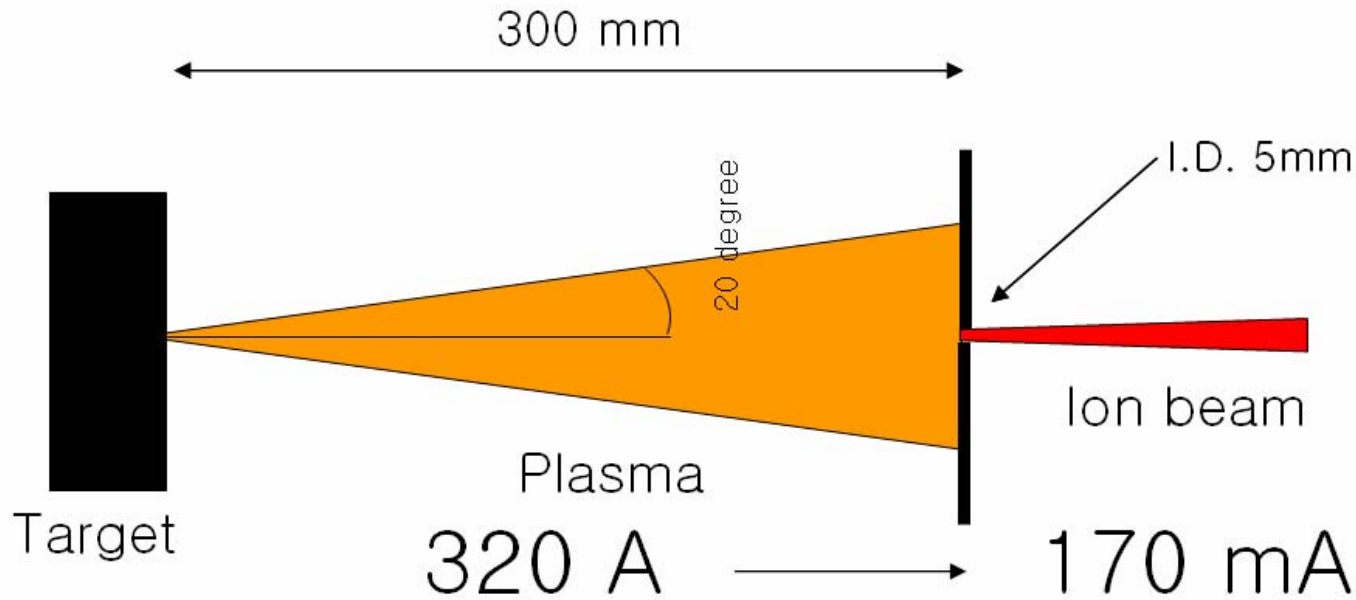
If we get $1 \mu\text{s}$ pulse with charge state $10+$ beam,

$$6.02 \times 10^{23} \times \frac{2700 \times \frac{1}{3} r^2 d}{27/1000} \times \frac{10 \times 1.60 \times 10^{-19}}{10^{-6}} = 32200 \text{ A}$$

Probably only 1% are ionized.

Roughly 320 A beam is produced.

Solid targets



The volume is:

$$\frac{1}{3} r^2 d = 3.33 \times 10^{-13} \text{ m}^3$$

Assuming an Aluminum target,

the density is about 2.7 g/cm^3 ,

and the volume contains;

$$2.0 \times 10^{16} \text{ ions.}$$

If we get $1 \mu\text{s}$ pulse with charge state $10+$ beam,

$$6.02 \times 10^{23} \times \frac{2700 \times \frac{1}{3} r^2 d}{27/1000} \times \frac{10 \times 1.60 \times 10^{-19}}{10^{-6}} = 32200 \text{ A}$$

Probably only 1% are ionized.

Roughly 320 A beam is produced.

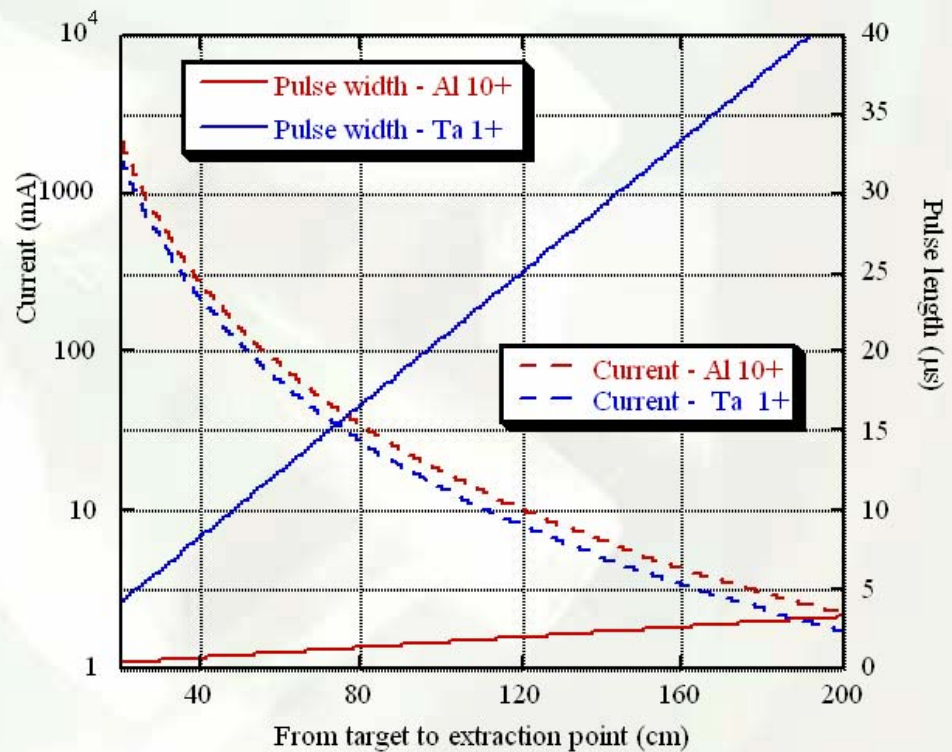
Beam current and Pulse length

$^{27}\text{Al}^{10+}$ and $^{181}\text{Ta}^{1+}$ ion currents (into 1 cm^2 aperture) and pulse lengths dependences on distance from targets.

$$\tau \propto L$$

$$I \propto L^{-3}$$

L : Distance from target to extraction point



Al - 3 J/30 ns Nd-glass 1062 nm laser (10^{11} W/cm^2)

Ta - 1 J/5 ns Nd-YAG 532 nm laser (10^9 W/cm^2)

LIS development for LHC



100 J/1 Hz MO-PA CO₂-laser system

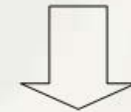
Requirements

- Ion species – Pb²⁵⁺
- Current – 8 mA
- Pulse length – 5.5 μ s
- Rep-rate – 1 Hz

High current

High charge states

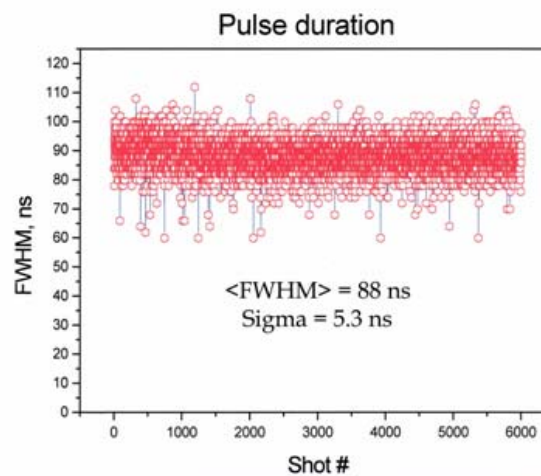
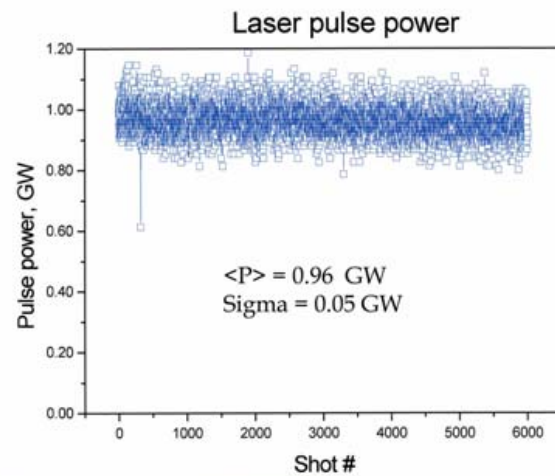
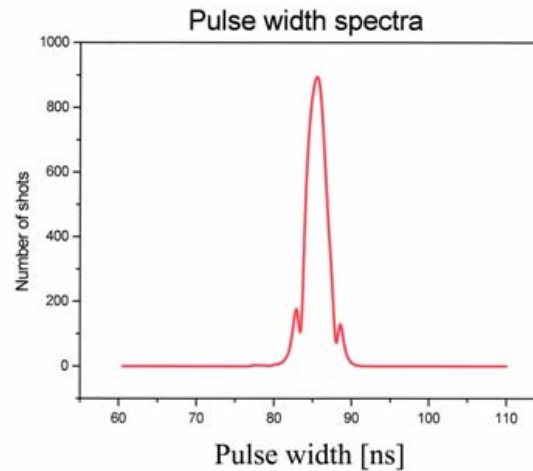
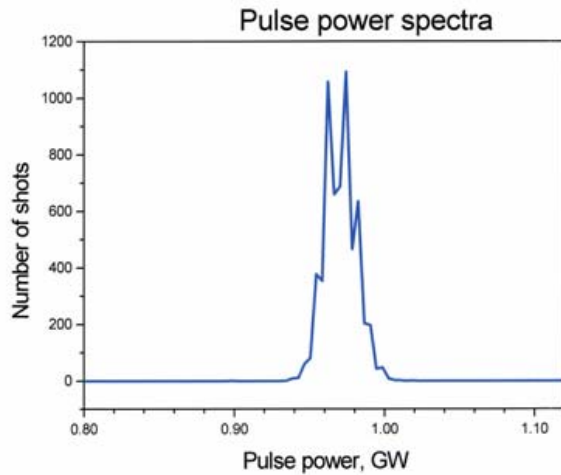
Long pulse



Powerful laser

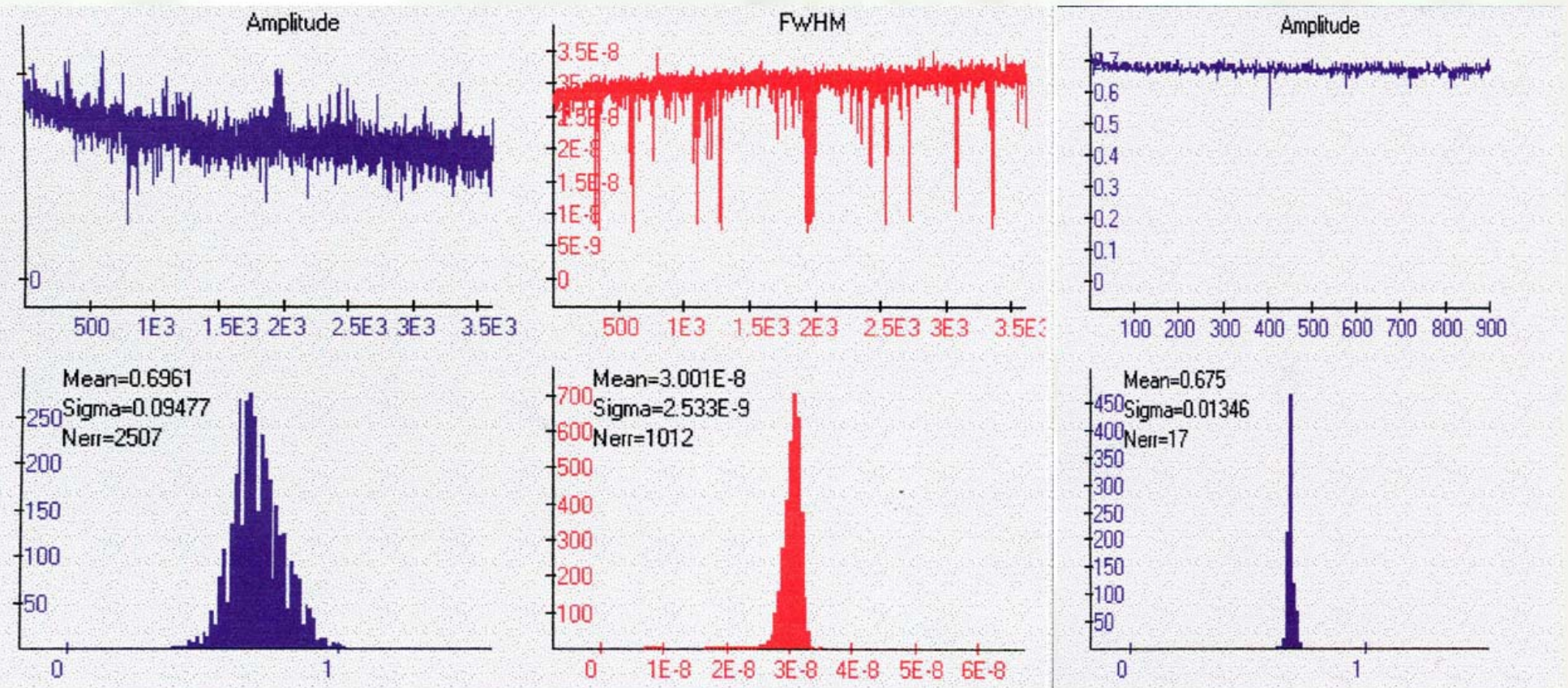
LIS development for LHC

Laser pulse statistics (generator mode)



LIS development for LHC

Laser pulse statistics (MO-PA mode)



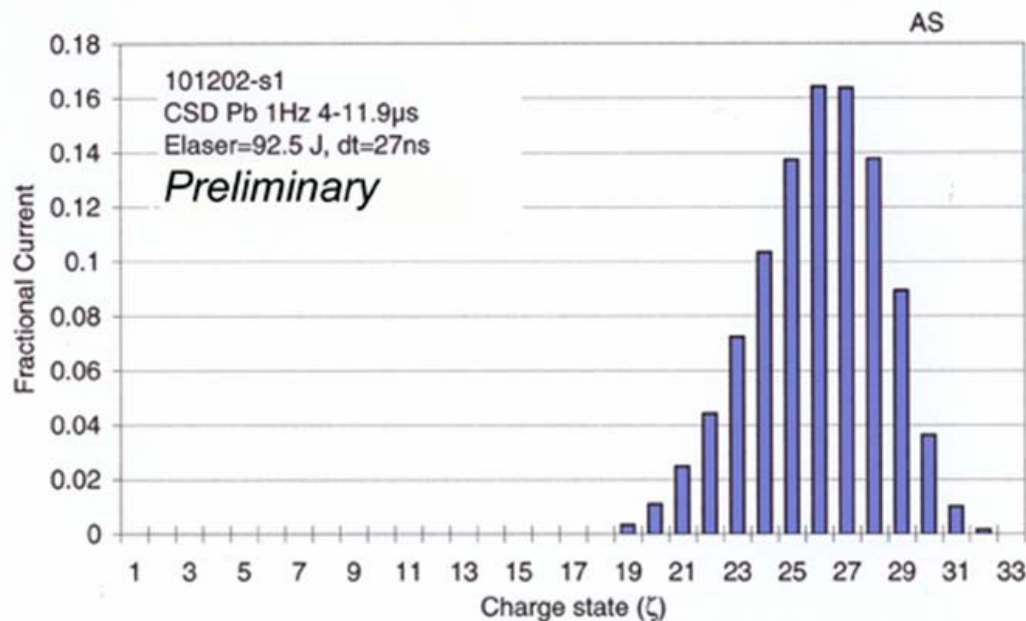
MO&PA 90 J operation of 1 hr 15 min at 1 Hz

1 hr 0.25 Hz

LIS development for LHC

Lead ion generation

First results from LIS - December 2002



This charge - state distribution, combined with an average current of 0.363 mA over 4 microseconds, 1750 mm from the target, leads to

2.3×10^{10} Pb²⁷⁺ ions at a pulselength of 3.6 microseconds

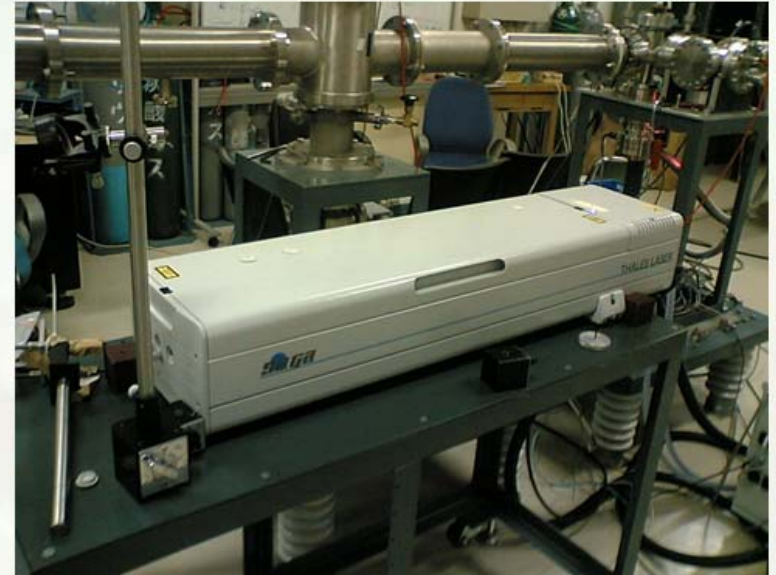
for the standard extraction geometry (aperture 34 mm)

The project was unfortunately stopped in 2003.

Need a powerful laser ??



Glass-laser



YAG-laser

Nd-Glass-Laser	B.M.industries SERIE 5000
Maximum energy	3.45 J – 30 ns
Wave length	1062 nm
Spot size	10 mm
Divergence	0.8 mrad
Repetition rate	45 second cooling time needed per shot

$\sim 10^{11}$ W/cm²

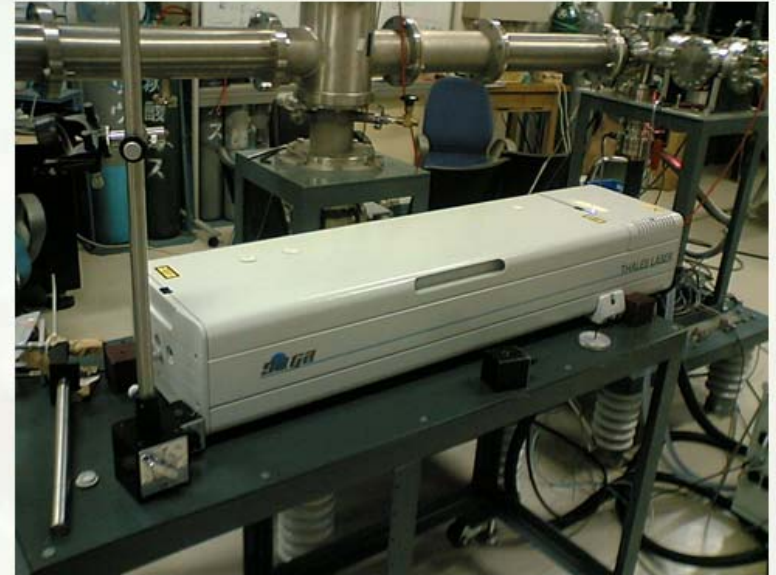
Nd-YAG-Laser	Thales SAGA230
Maximum energy	2.36 J – 6 ns
Wave length	1064 nm
Spot size	17 mm
Divergence	0.5 mrad
Repetition rate	Maximum 10 Hz

$\sim 10^{12}$ W/cm²

Need a powerful laser ??



Glass-laser



YAG-laser

Nd-Glass-Laser	B.M.industries SERIE 5000
Maximum energy	3.45 J – 30 ns
Wave length	1062 nm
Spot size	10 mm
Divergence	0.8 mrad
Repetition rate	45 second cooling time needed per shot

$\sim 10^{11}$ W/cm²

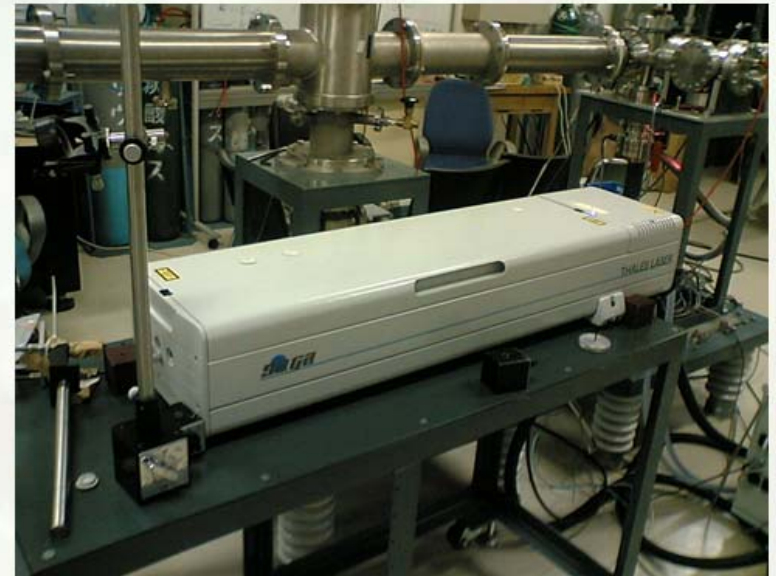
Nd-YAG-Laser	Thales SAGA230
Maximum energy	2.36 J – 6 ns
Wave length	1064 nm
Spot size	17 mm
Divergence	0.5 mrad
Repetition rate	Maximum 10 Hz

$\sim 10^{12}$ W/cm²

Plasmas using conventional lasers in RIKEN



Glass-laser



YAG-laser

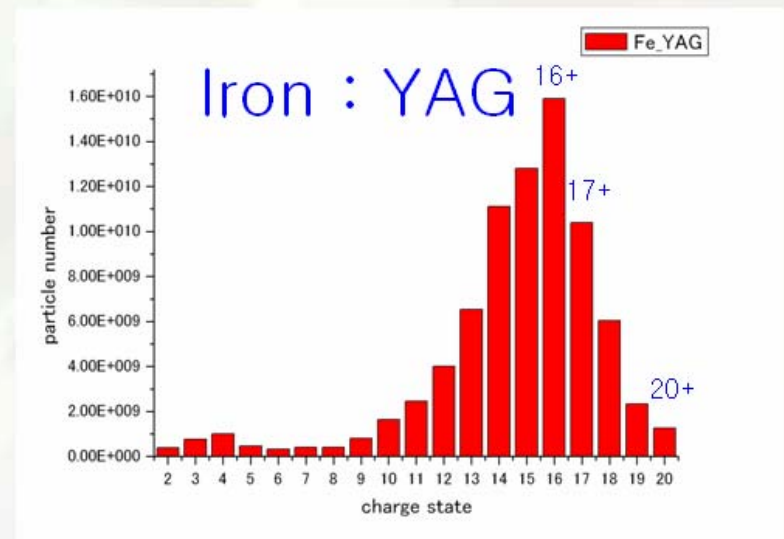
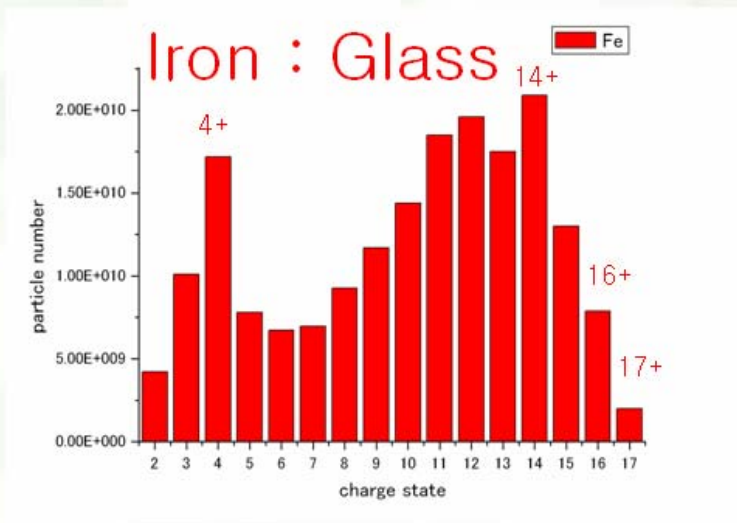
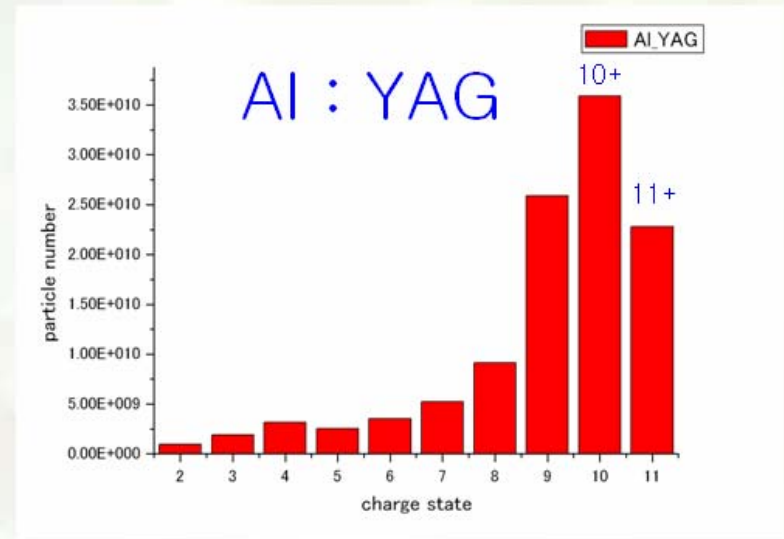
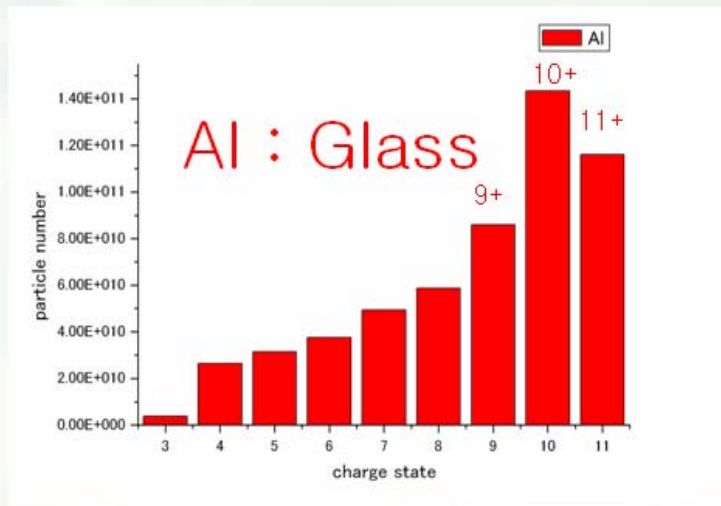
Nd-Glass-Laser	B.M.industries SERIE 5000
Maximum energy	3.45 J – 30 ns
Wave length	1062 nm
Spot size	10 mm
Divergence	0.8 mrad
Repetition rate	45 second cooling time needed per shot

$\sim 10^{11}$ W/cm²

Nd-YAG-Laser	Thales SAGA230
Maximum energy	2.36 J – 6 ns
Wave length	1064 nm
Spot size	17 mm
Divergence	0.5 mrad
Repetition rate	Maximum 10 Hz

$\sim 10^{12}$ W/cm²

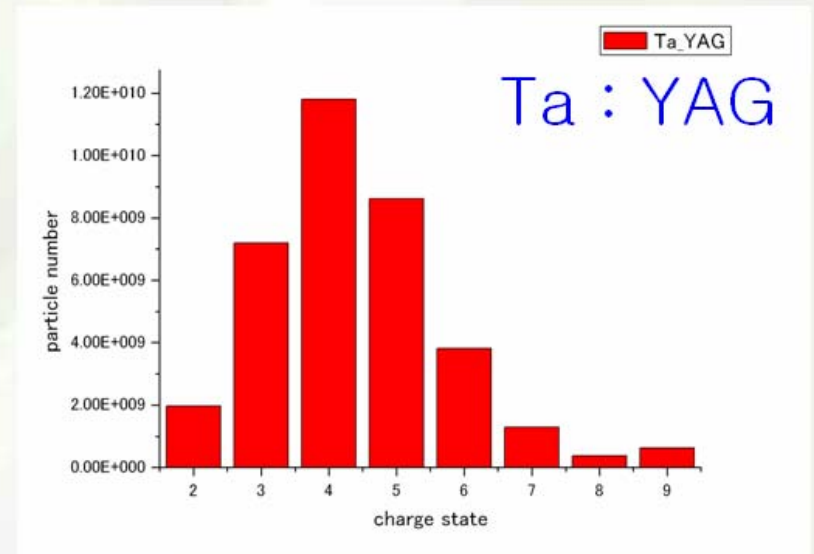
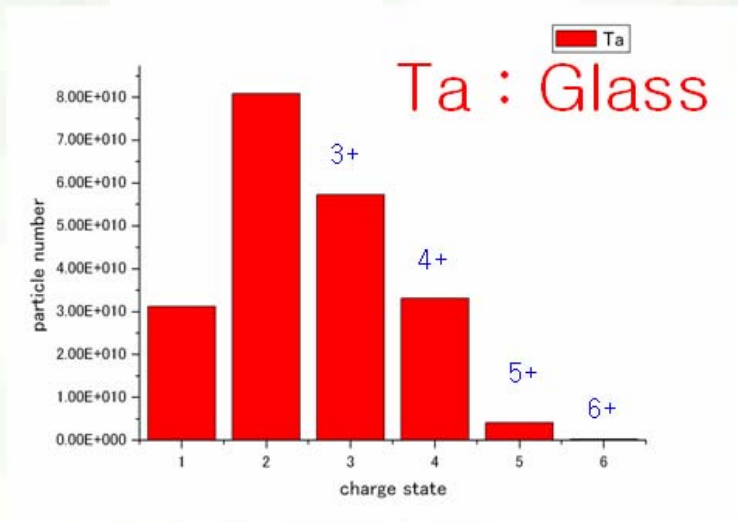
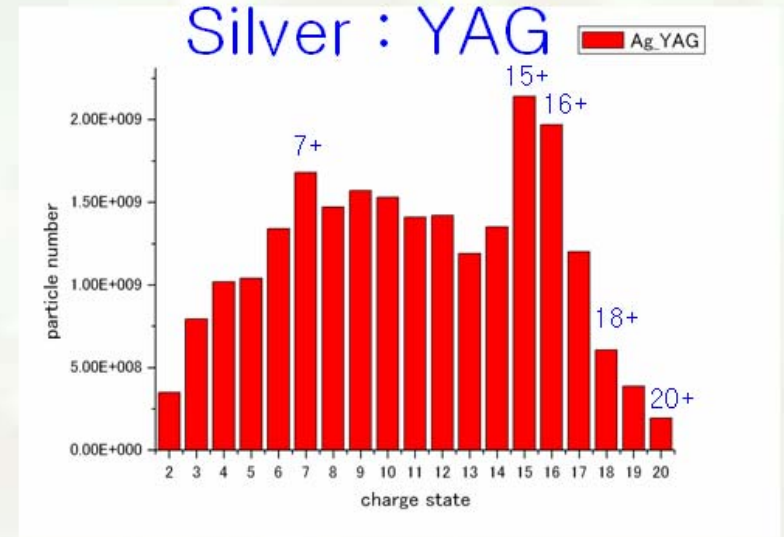
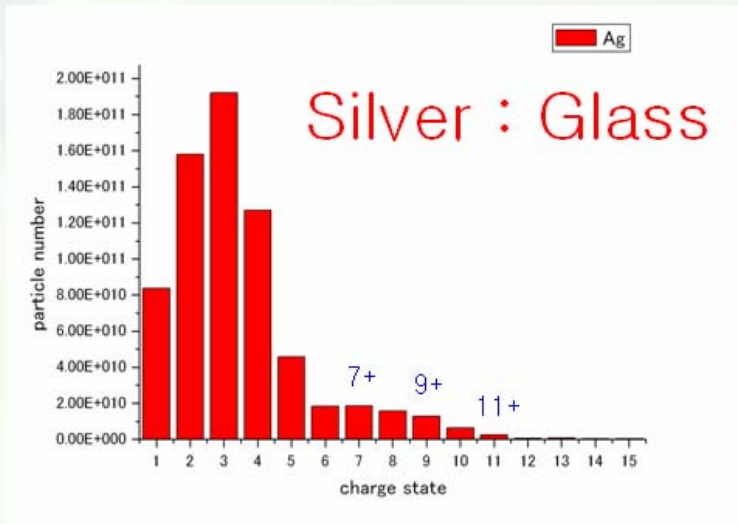
Charge states distribution using small lasers



$\sim 10^{11}$ W/cm²

$\sim 10^{12}$ W/cm²

Charge states distribution using small lasers



$\sim 10^{11}$ W/cm²

$\sim 10^{12}$ W/cm²

Charge states using small lasers

	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18
1	1																	2
	H																	He
2	3	4																
	Li	Be																
3	11	12																
	Na	Mg																
4	19	20	21	22	23	24	25	26	27	28	29	30	31	32	33	34	35	36
	K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
5	37	38	39	40	41	42	43	44	45	46	47	48	49	50	51	52	53	54
	Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe
6	55	56	*	72	73	74	75	76	77	78	79	80	81	82	83	84	85	86
	Cs	Ba		Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg	Tl	Pb	Bi	Po	At	Rn
7	87	88	**	104	105	106	107	108	109									
	Fr	Ra		Rf	Db	Sg	Bh	Hs	Mt									

■ Glass-laser 10^{11} W/cm²
■ YAG-laser 10^{12} W/cm²

○ Glass laser : Fe¹⁷⁺
○ YAG laser : Ag²⁰⁺

The heavier species need the higher laser power density.

→ High power laser

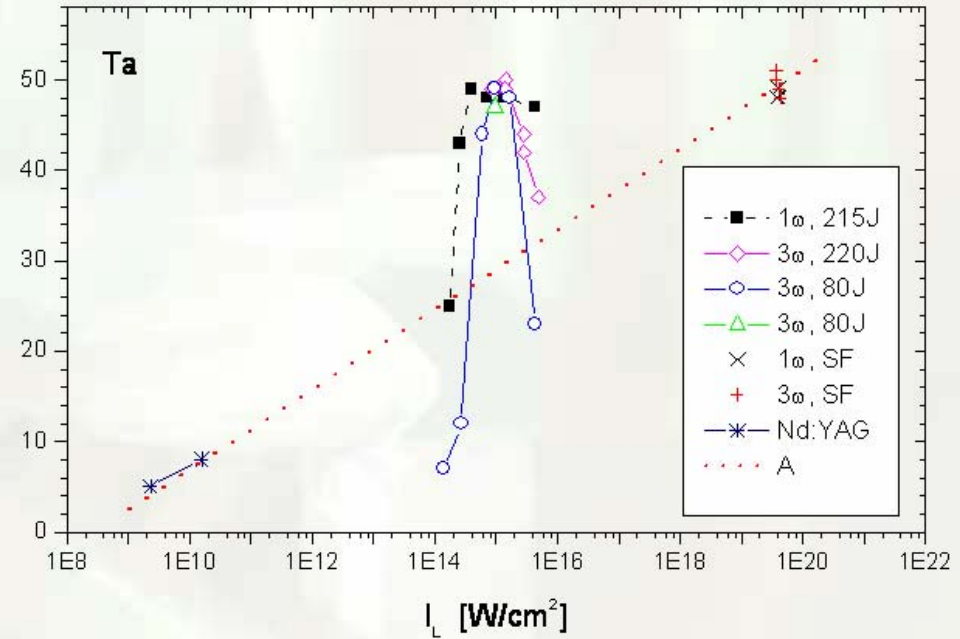
or

→ Short pulse laser

Need really high charge states ??



Iodine laser at the PALS Research Center in Prague
 $\lambda = 1.315 \mu\text{m}$, $E \leq 1 \text{ KJ}$, $8 \times 10^{16} \text{ W/cm}^2$



Obtained maximum charge states from Ta.

Element	$^{59}_{27}\text{Co}$	$^{69}_{28}\text{Ni}$	$^{108}_{47}\text{Ag}$	$^{119}_{50}\text{Sn}$	$^{181}_{73}\text{Ta}$	$^{184}_{74}\text{W}$	$^{195}_{78}\text{Pt}$	$^{197}_{79}\text{Au}$	$^{207}_{82}\text{Pb}$	$^{209}_{83}\text{Bi}$
Z_{max}	25	26	38	38	55	49	50	51	51	51
E_{jmax} (MeV)	2.6	2.5	3.6	3.5	34	4.9	8.5	4.8	5.1	5.1
j^* (mA/cm 2)	32.4	24.2	27.5	22.3	49.0	24.2	19.2	21.9	19.8	13.0

*Recalculated to the distance of 100 cm ($j \sim 1/L^3$)

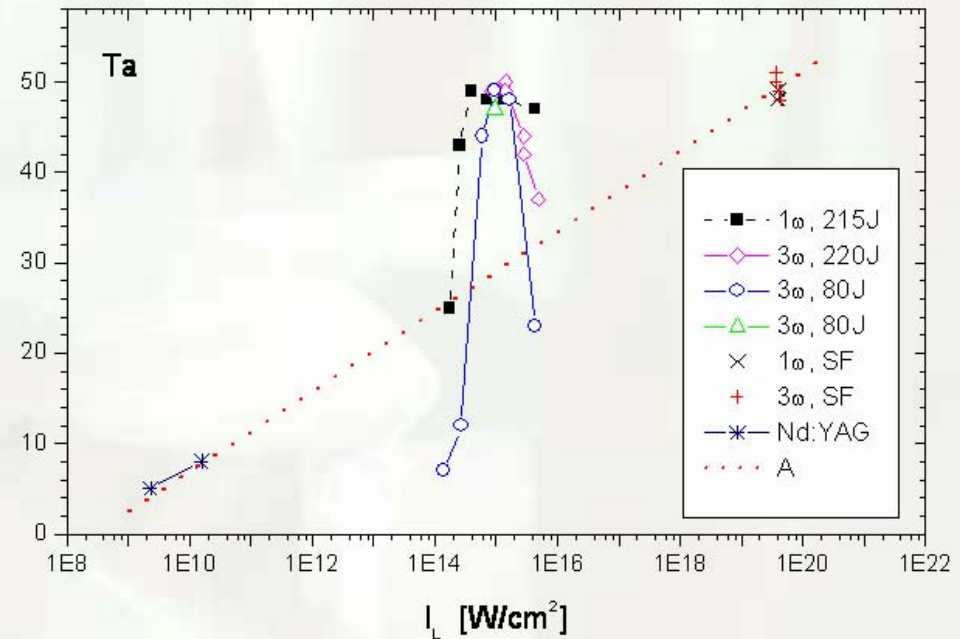
A short pulse laser is good for accelerator application.
 (We plan to verify this in next step)

Courtesy of Dr. L. L'aska

Plasmas with a high power laser density



Iodine laser at the PALS Research Center in Prague
 $\lambda = 1.315 \mu\text{m}$, $E \leq 1 \text{ KJ}$, $8 \times 10^{16} \text{ W/cm}^2$



Obtained maximum charge states from Ta.

Element	$^{59}_{27}\text{Co}$	$^{58}_{28}\text{Ni}$	$^{108}_{47}\text{Ag}$	$^{119}_{50}\text{Sn}$	$^{181}_{73}\text{Ta}$	$^{184}_{74}\text{W}$	$^{195}_{78}\text{Pt}$	$^{197}_{79}\text{Au}$	$^{207}_{82}\text{Pb}$	$^{209}_{83}\text{Bi}$
Z_{max}	25	26	38	38	55	49	50	51	51	51
E_{jmax} (MeV)	2.6	2.5	3.6	3.5	34	4.9	8.5	4.8	5.1	5.1
j^* (mA/cm 2)	32.4	24.2	27.5	22.3	49.0	24.2	19.2	21.9	19.8	13.0

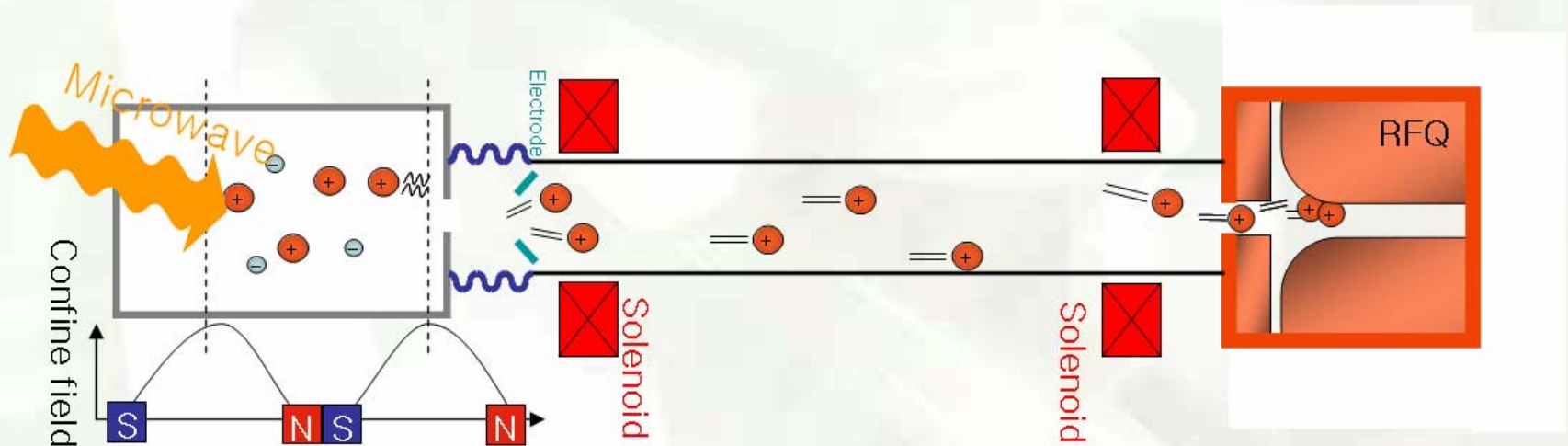
*Recalculated to the distance of 100 cm ($j \sim 1/L^3$)

A short pulse laser is good for accelerator application.
 (We plan to verify this in next step)

Courtesy of Dr. L. L'aska

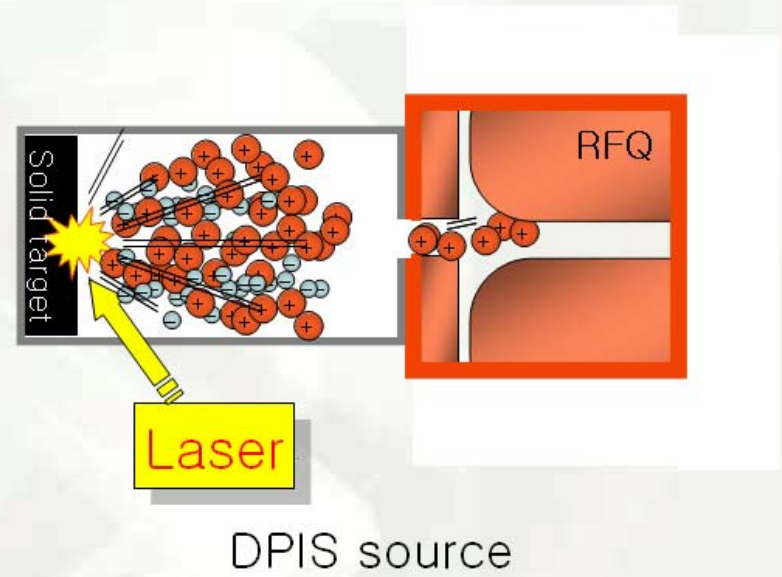
We can provide ultra high current, but,,

It's not so easy to put it into an RFQ!!

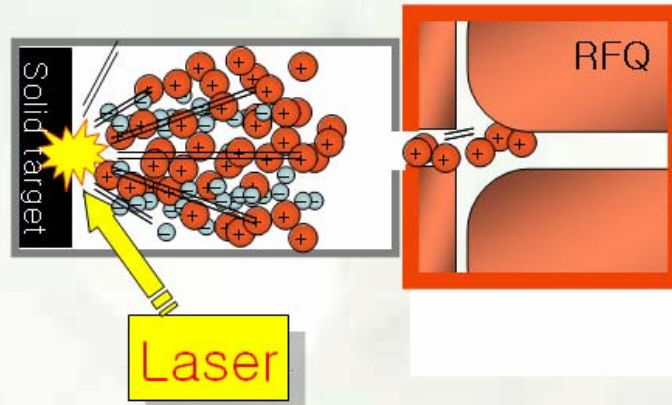


Traditional injection scheme

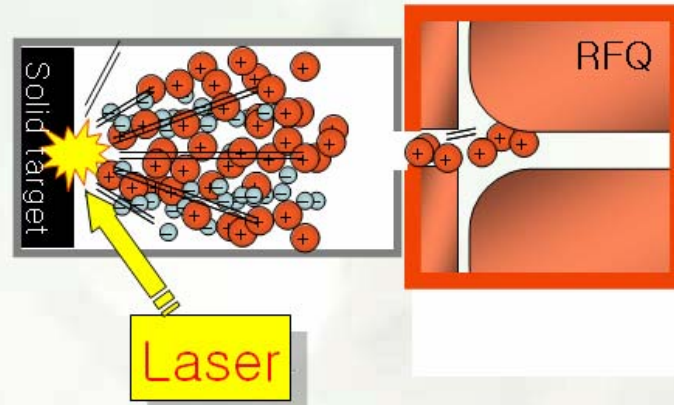
Direct Plasma Injection Scheme (DPIS)



Direct Plasma Injection Scheme (DPIS)

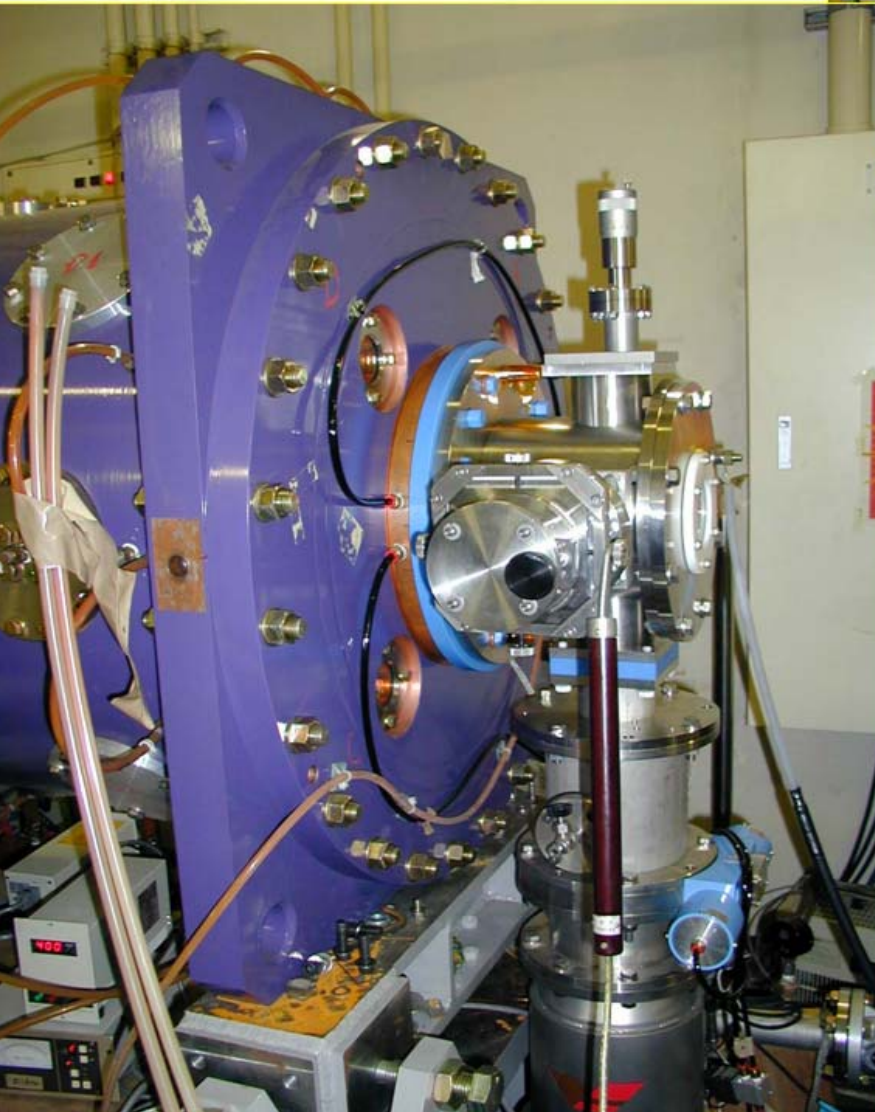


Direct Plasma Injection Scheme (DPIS)



- Dense expanding plasma from solid targets.
- Retaining high brightness, heavy ions can be delivered to RFQ.
- Since ions in plasma, space charge effect can be neglected.
- No focusing lenses.
- No high voltage cage, no isolating transformer.
- Low construction cost.
- Low operation cost.

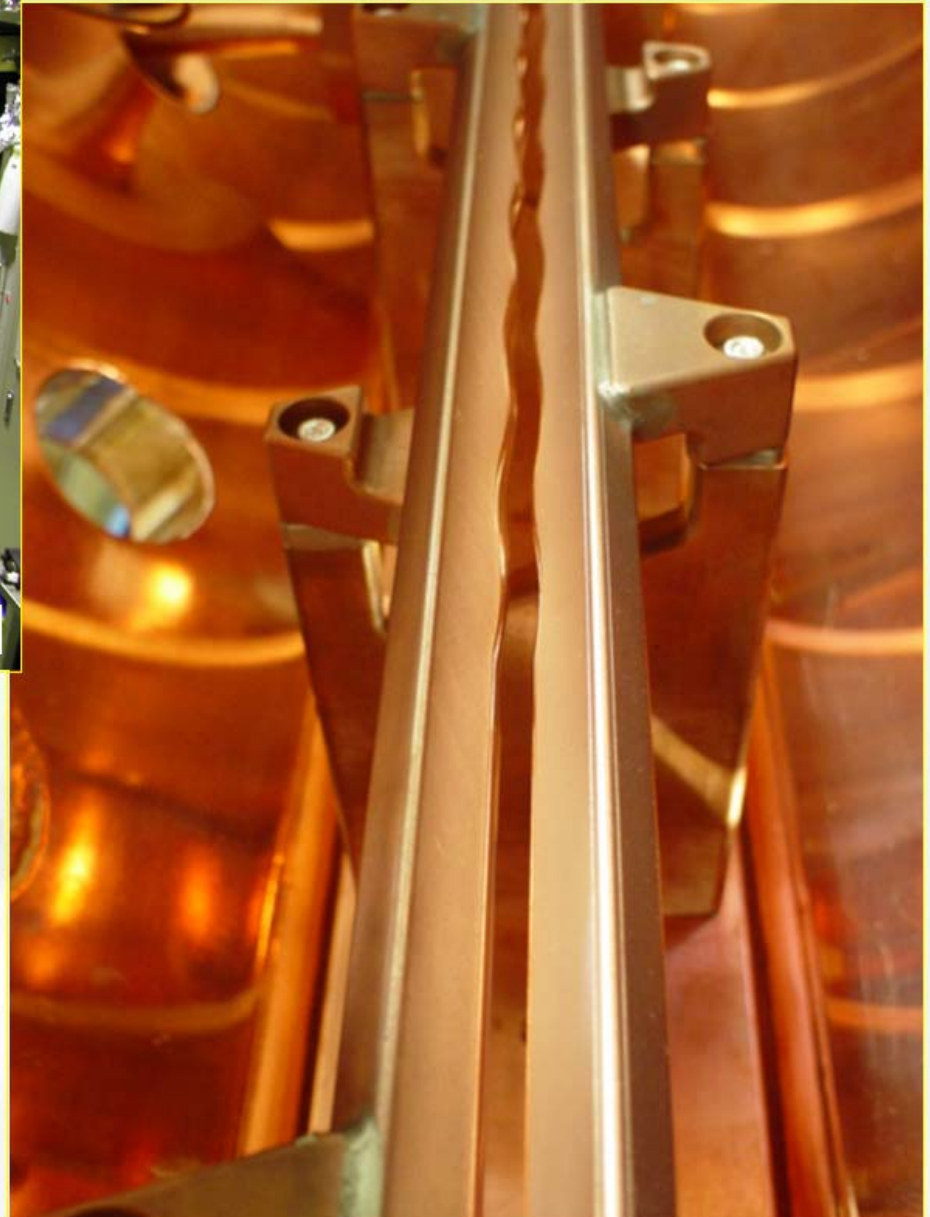
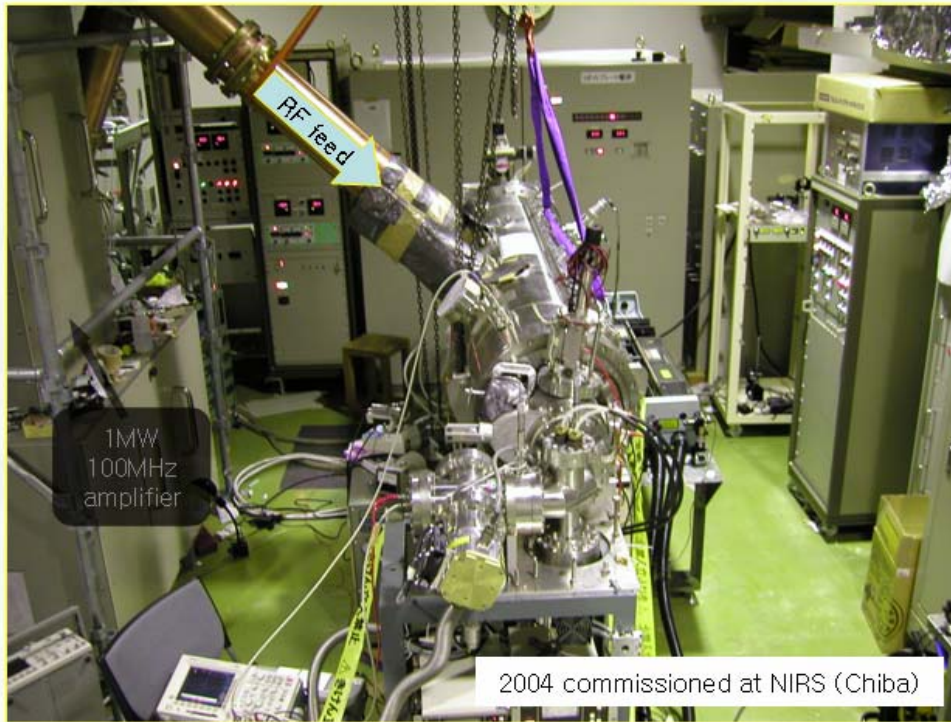
First DPIS (2001) at TITech (Tokyo)



9 mA (peak total) Carbon was obtained.

Charge to mass ratio	$\geq 1/16$
Operating frequency (MHz)	80
Input energy (keV/amu)	5
Output energy (keV/amu)	214
Normalized emittance(100%) (cm·mrad)	0.05p
Vane length (cm)	422
Total number of cells	273
Characteristic bore radius, r_0 (cm)	0.466
Synchronous phase, ϕ_s	-90° to -20°
Transmission for $q/A=1/16$ beam 10 mA input	6.84 mA

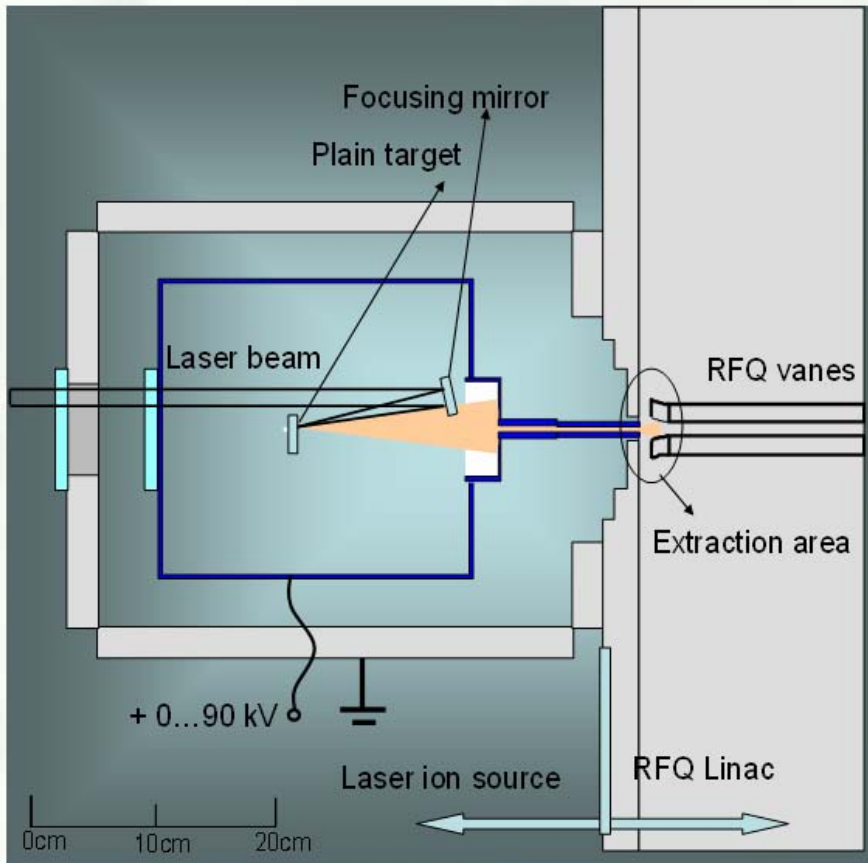
Newly designed RFQ for DPIS



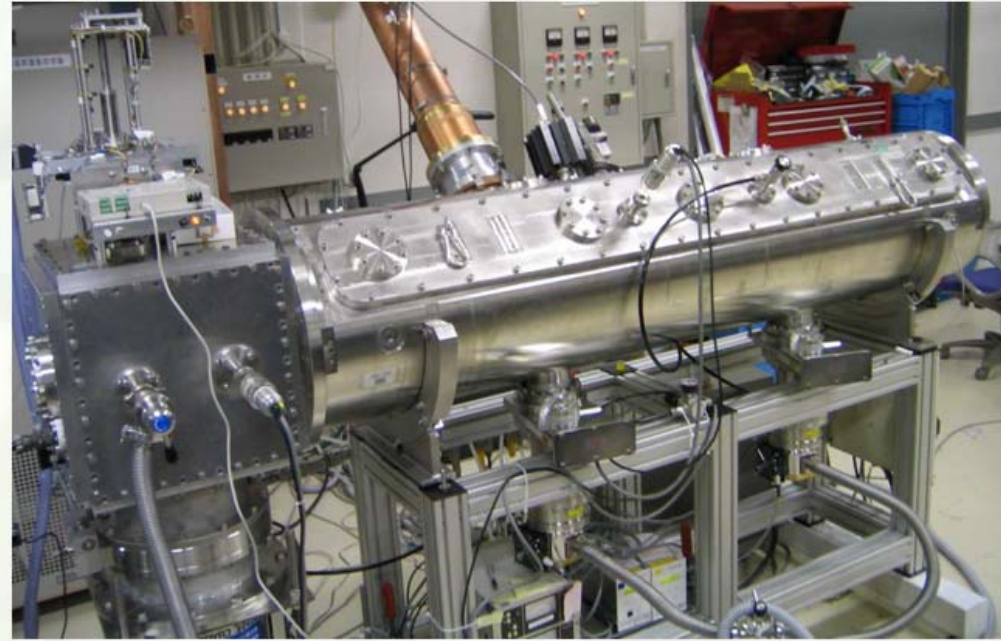
Length of Vane Modulated portion	1.42 m
Frequency	100 MHz
Radius of Aperture	6.55 mm
Nominal RF Voltage	120 kV
Nominal RF Power	200 kW
Ion Charge State-to-Mass Ratio (Z/A)	$\geq 1/3$
Input Energy	20 keV/u
Output Energy	100 keV/u
Output Current for 100 mA $^{12}\text{C}^{4+}$ Ion Injection (Result of Simulations)	76 mA

The RFQ was dedicatedly designed and fabricated for DPIS collaborating with A. Schempp and R. A. Jameson.

Ion source box



Source box



DPIS at RIKEN

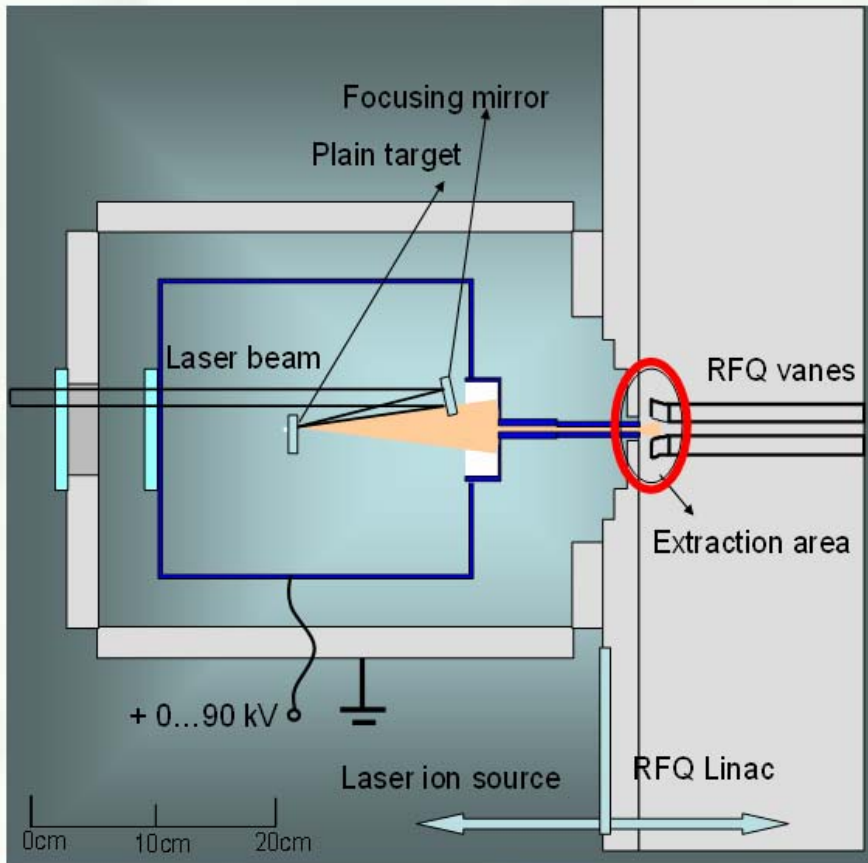
Accelerated total peak current after the RFQ, 100 keV/u

2004 Carbon beam with 4 J CO₂ laser. 60 mA

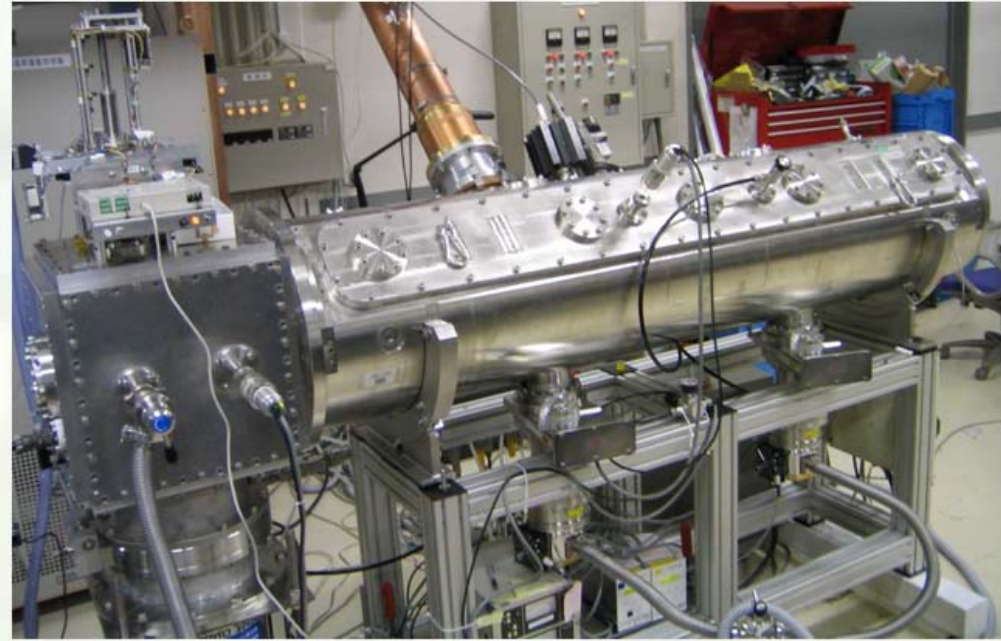
2005 Bare carbon beam with 300 mJ YAG laser, 17 mA

2006 Al beam with 2.3 J YAG laser, 70 mA

Ion source box



Source box



DPIS at RIKEN

Accelerated total peak current after the RFQ, 100 keV/u

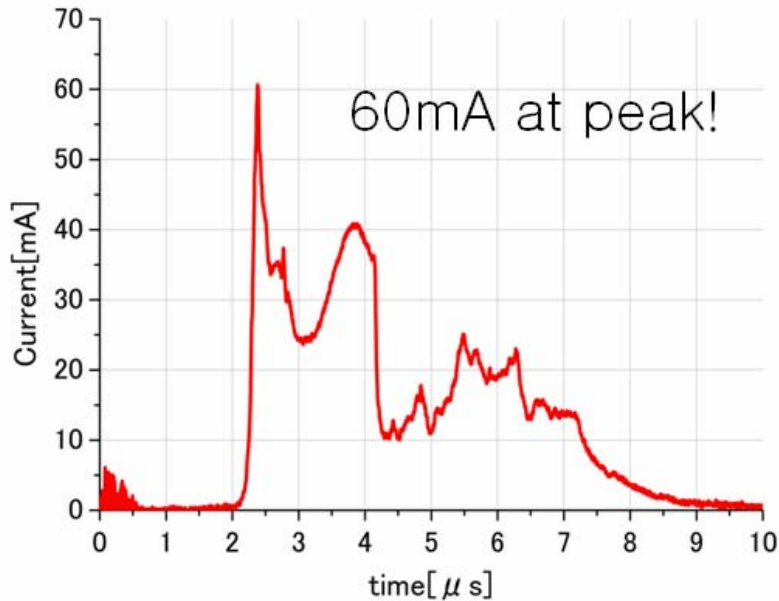
2004 Carbon beam with 4 J CO₂ laser. 60 mA

2005 Bare carbon beam with 300 mJ YAG laser, 17 mA

2006 Al beam with 2.3 J YAG laser, 70 mA

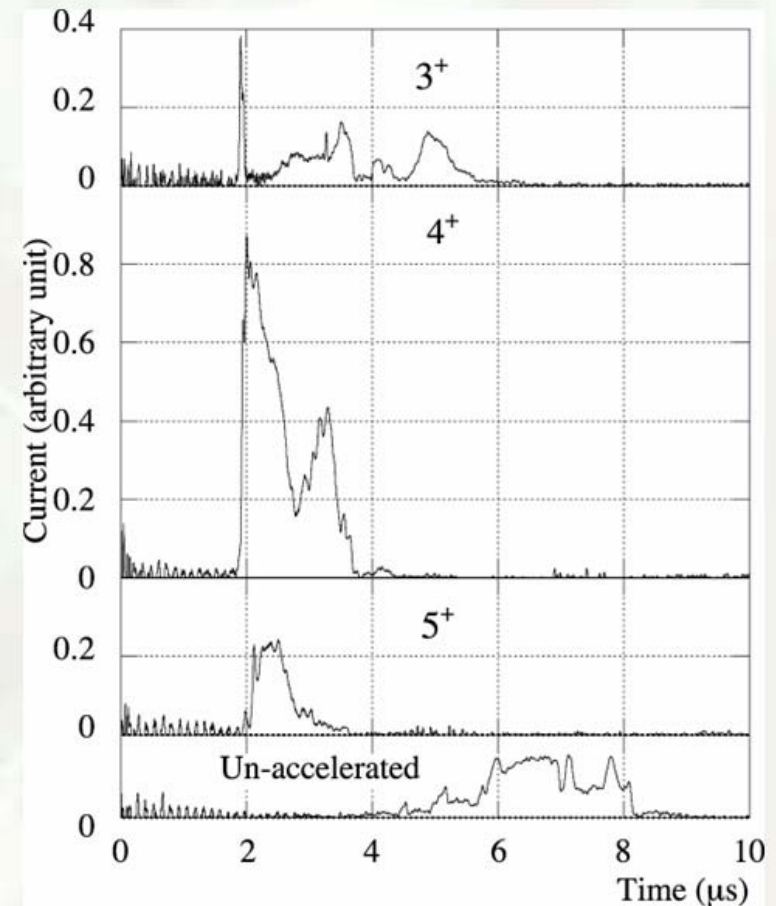
Carbon with 4 J CO₂ laser

Total current after RFQ



	Peak	Integral
C ⁵⁺	26%	24%
C ⁴⁺	64%	60%
C ³⁺	10%	16%

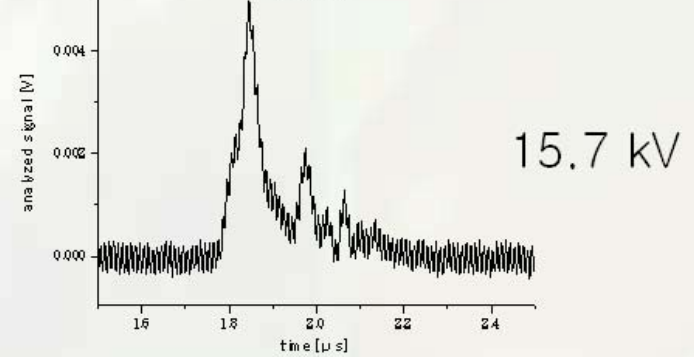
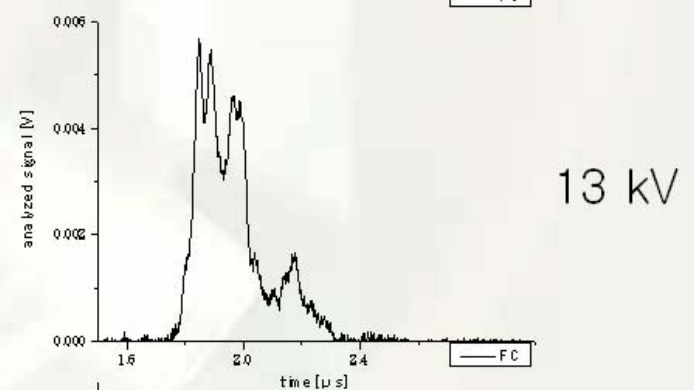
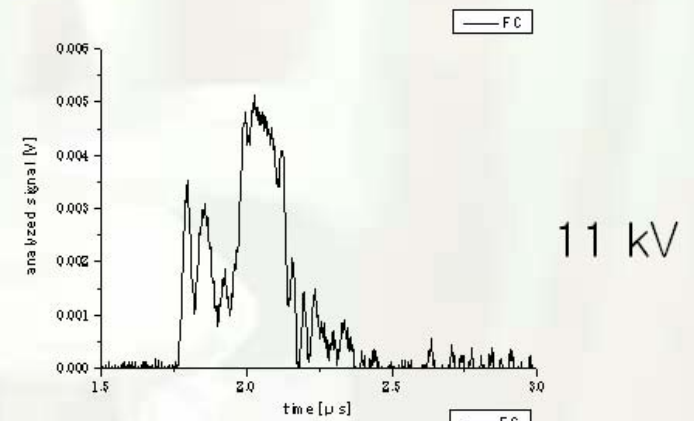
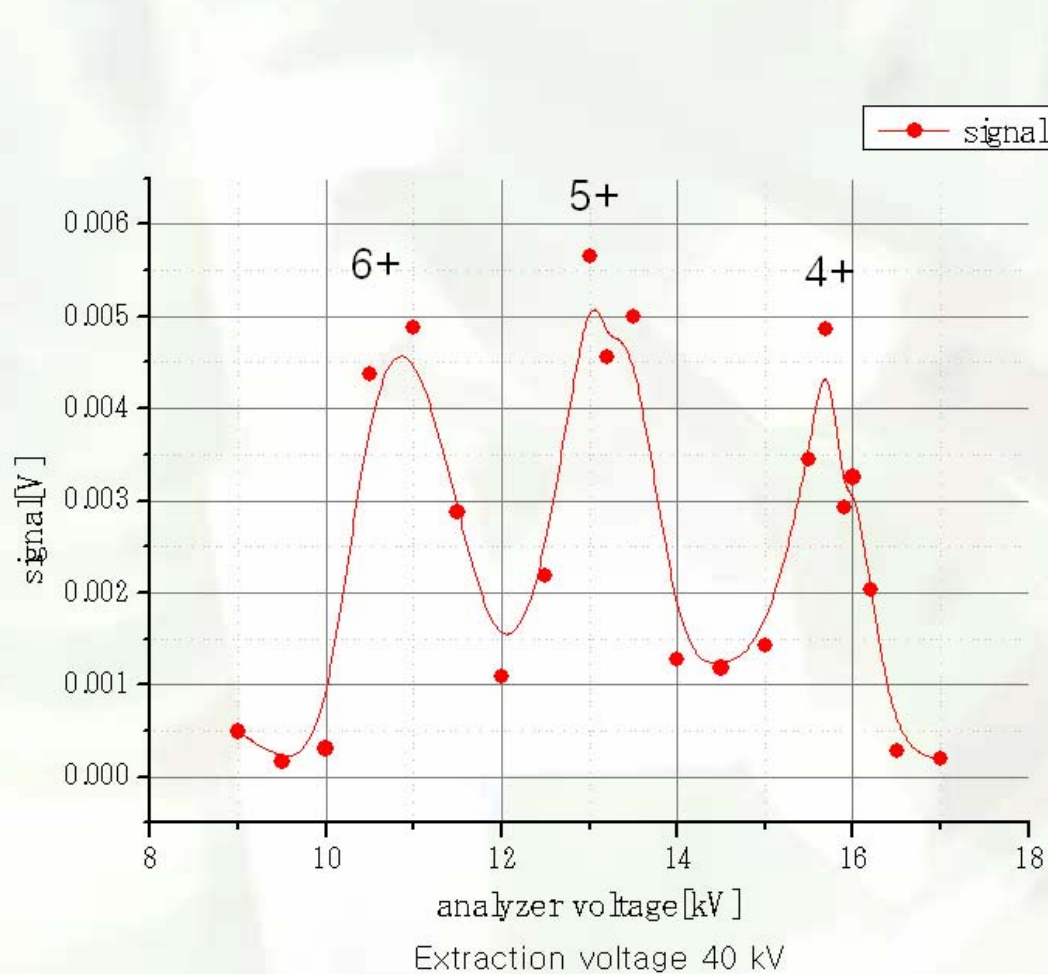
Analyzed signals



➔ 35mA at peak C⁴⁺
6.3 × 10¹⁰ C⁴⁺ particles

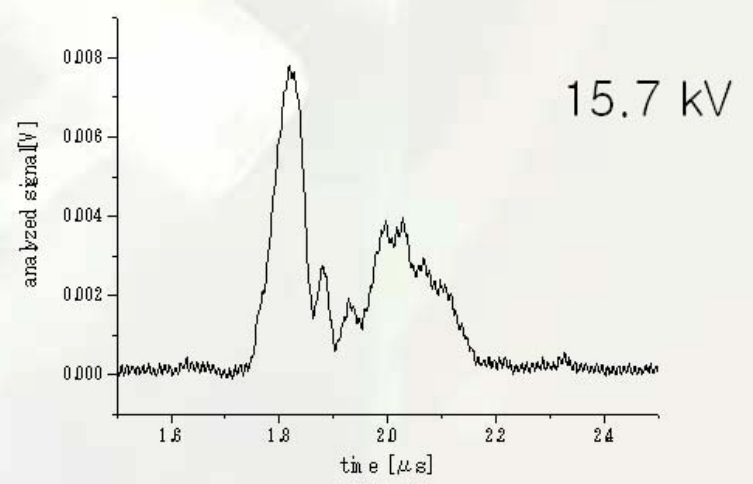
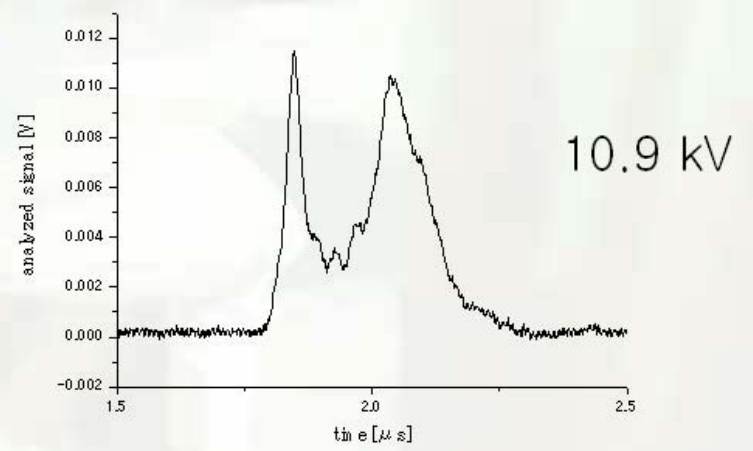
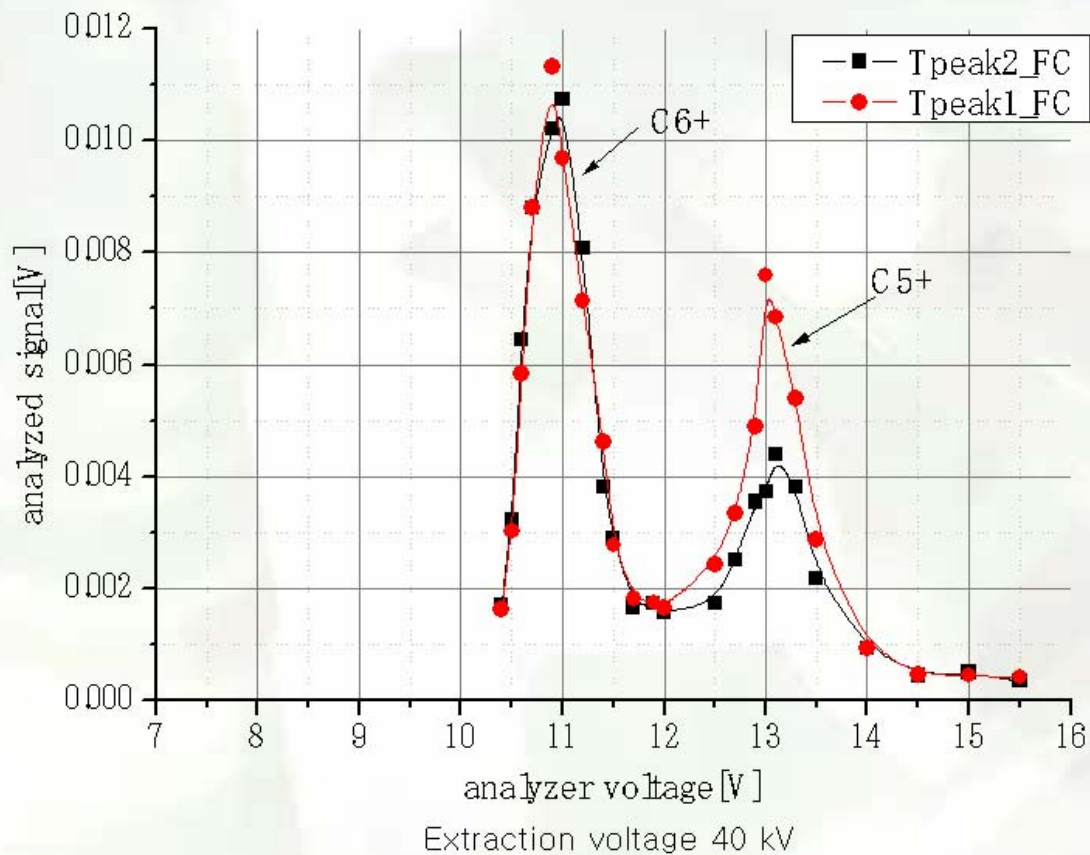
Carbon with 300 mJ YAG laser

RFQ voltage : 100 %



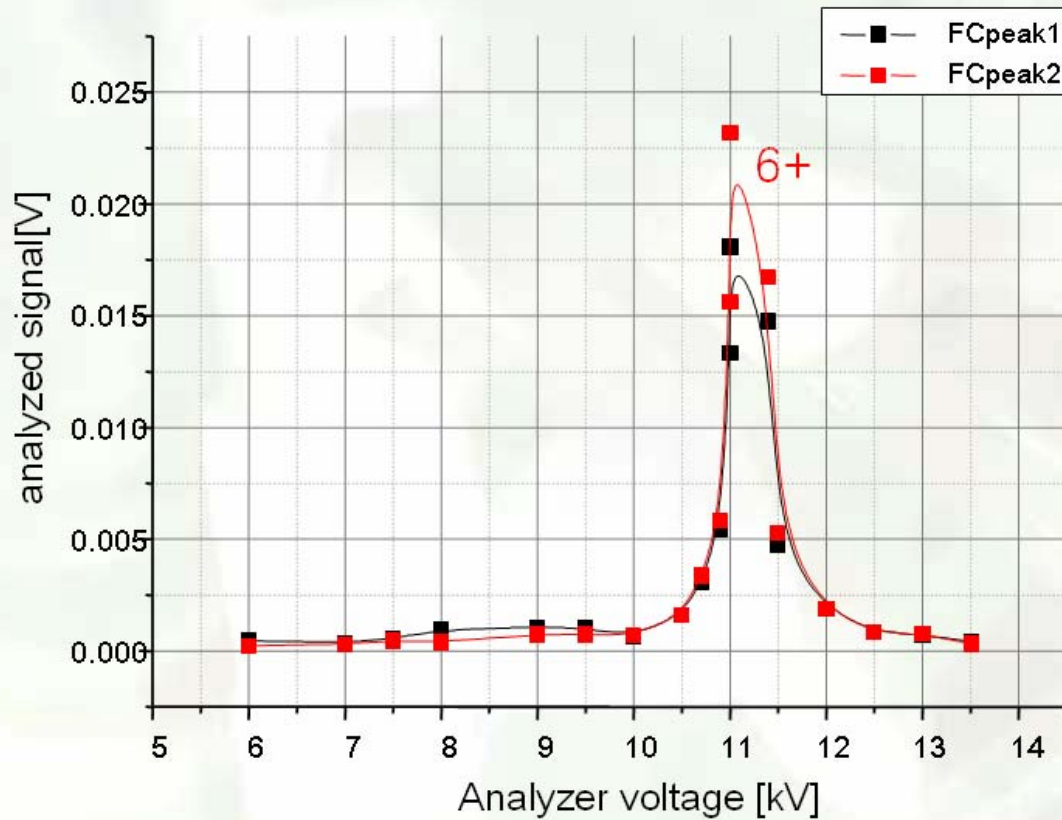
Carbon with 300 mJ YAG laser

RFQ voltage : 75 %

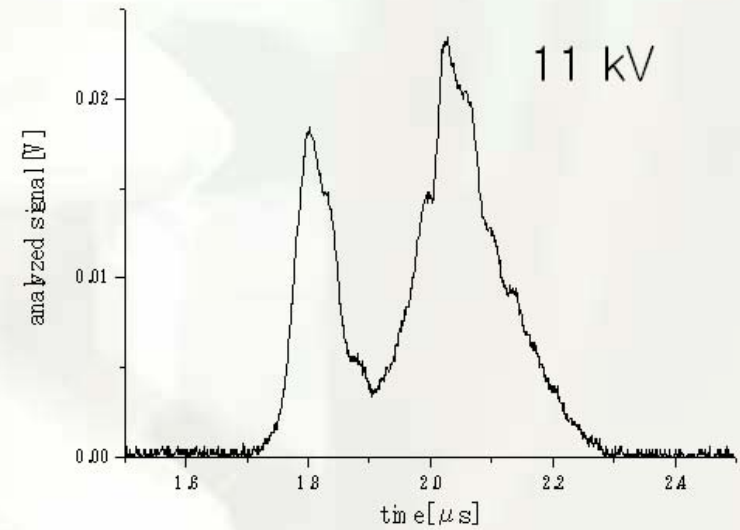


Carbon with 300 mJ YAG laser

RFQ voltage : 61 %



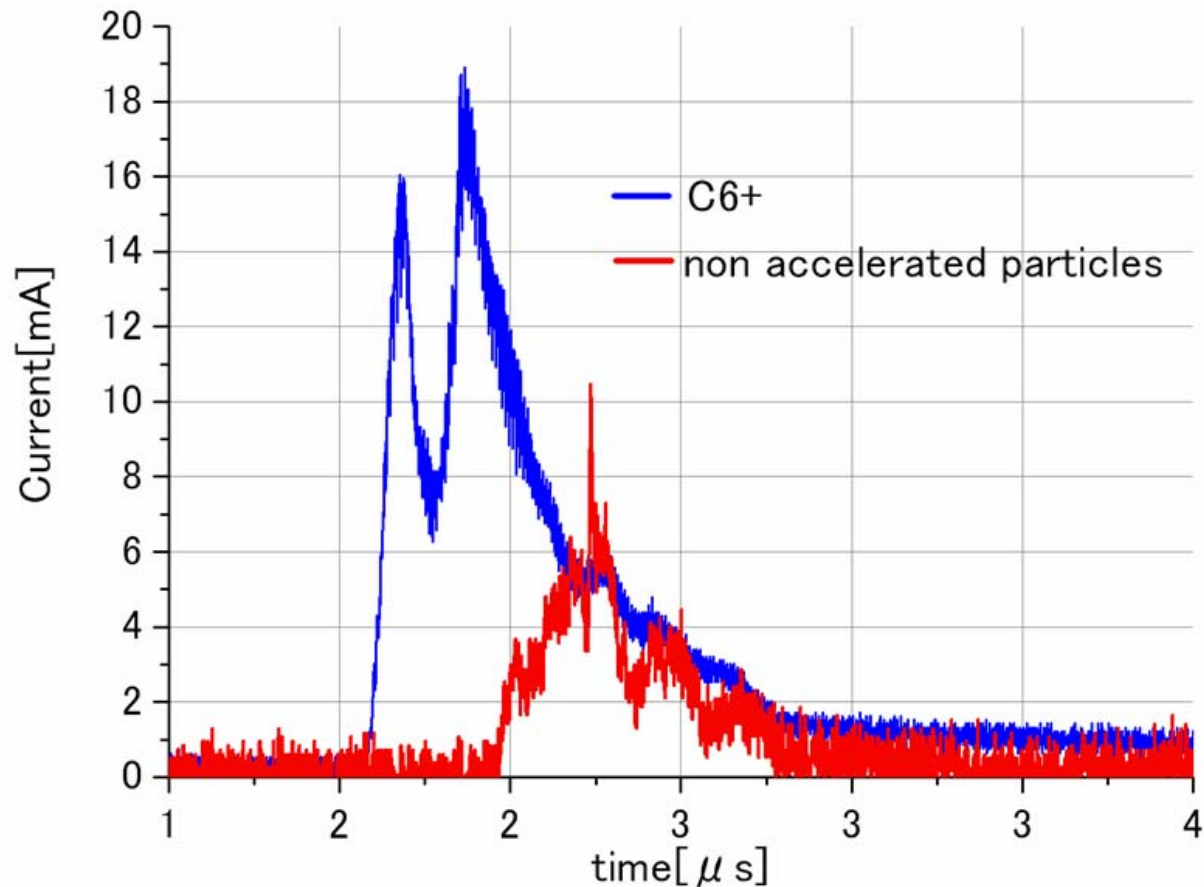
Extraction voltage 40 kV



Pure 6+ beam can be delivered by adjusting operating condition of the RFQ.

Carbon with 300 mJ YAG laser

RFQ voltage : 61 %



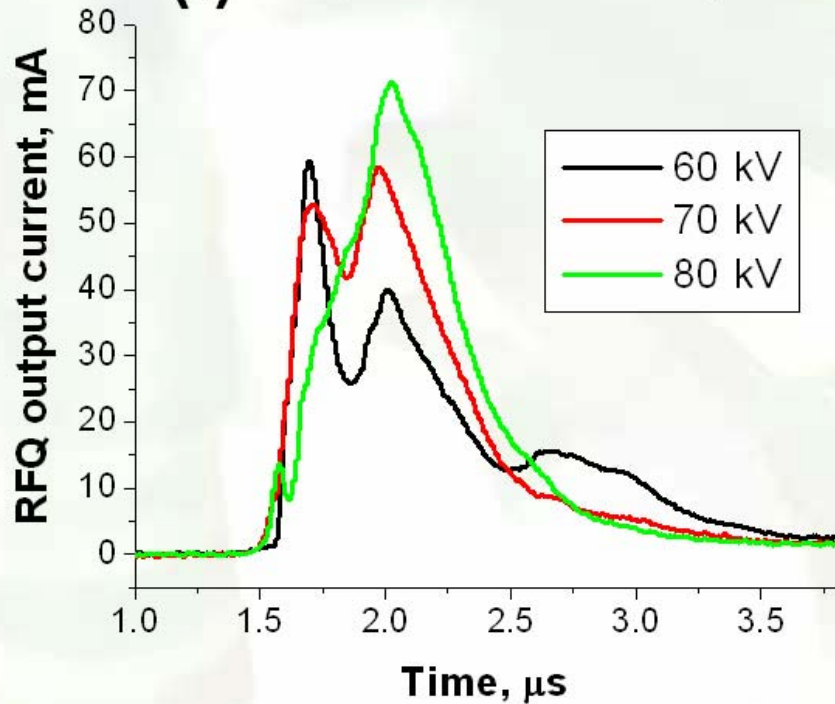
17mA

C^{6+} peak current

Number of particles : 6.0×10^9

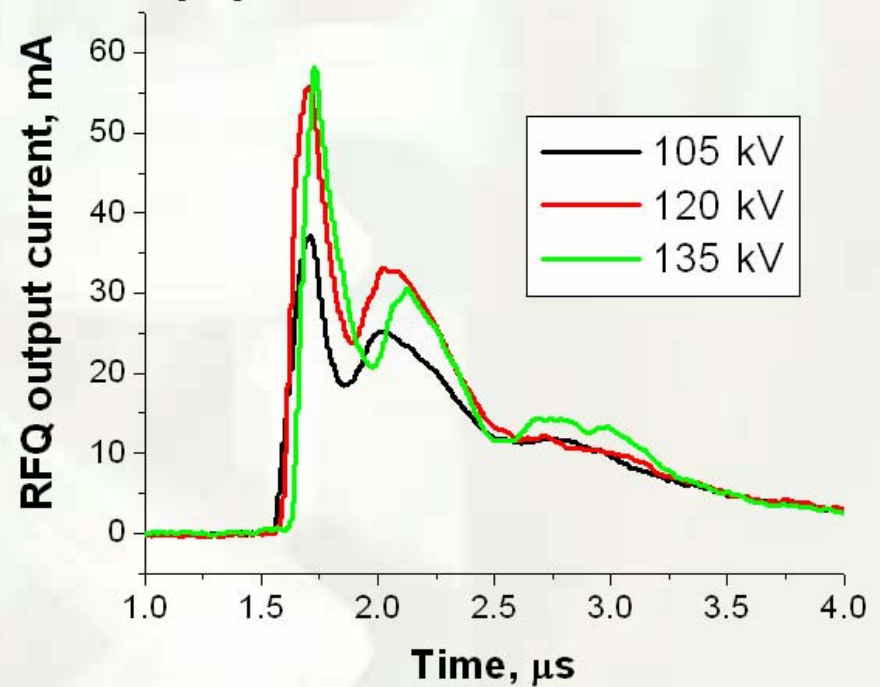
Aluminum with 2.3 J YAG laser

(I) Amplitude of RF voltage - 120 kV



Extraction voltage scan

(II) Extraction potential - 60 kV



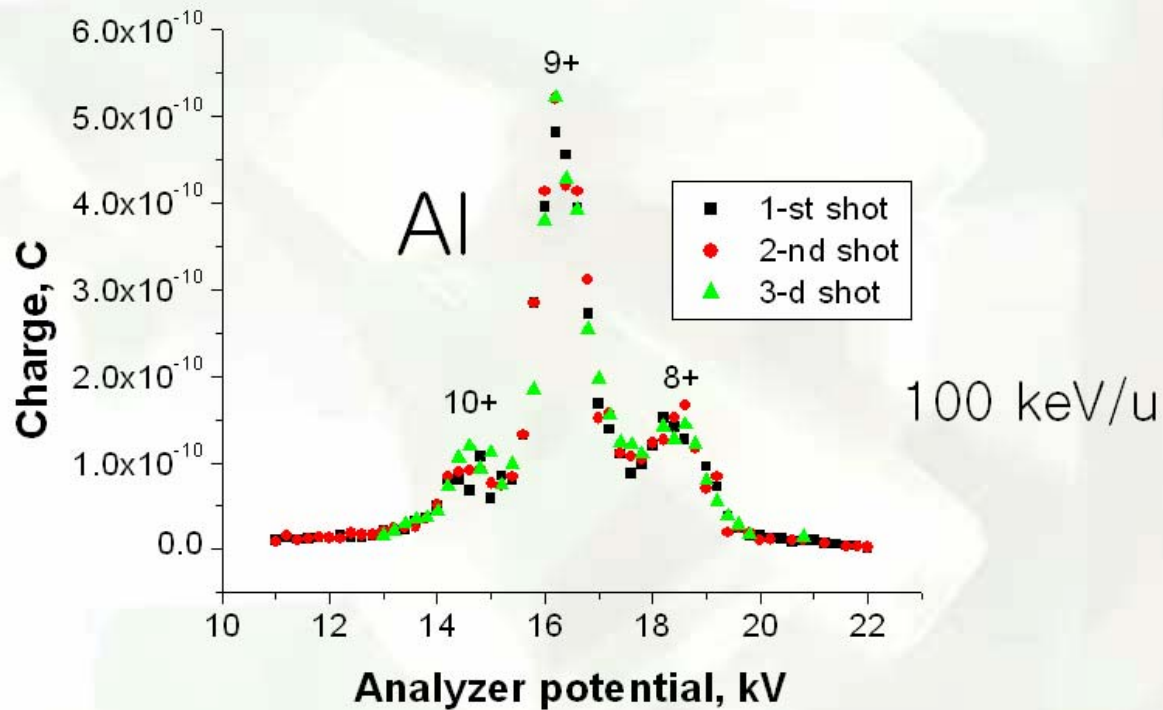
RFQ voltage scan

Laser spot size setting was optimized to get Al^{9+} .

Aluminum with 2.3 J YAG laser

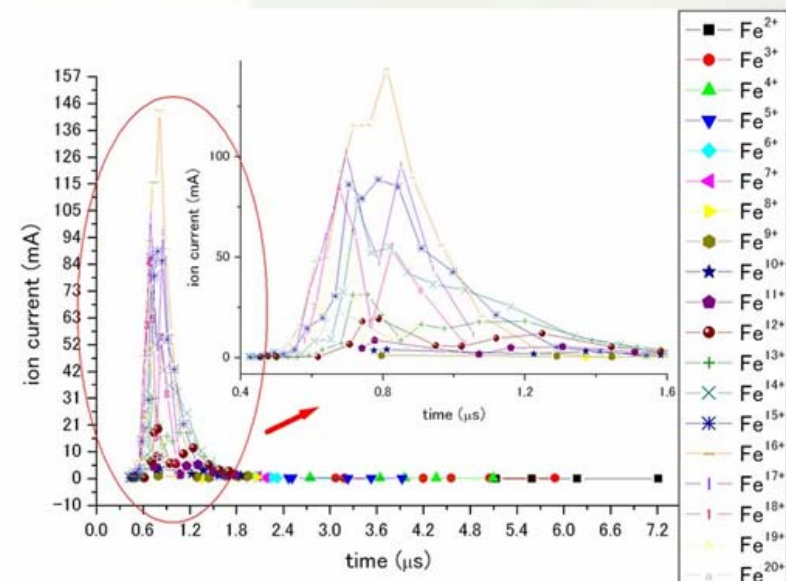
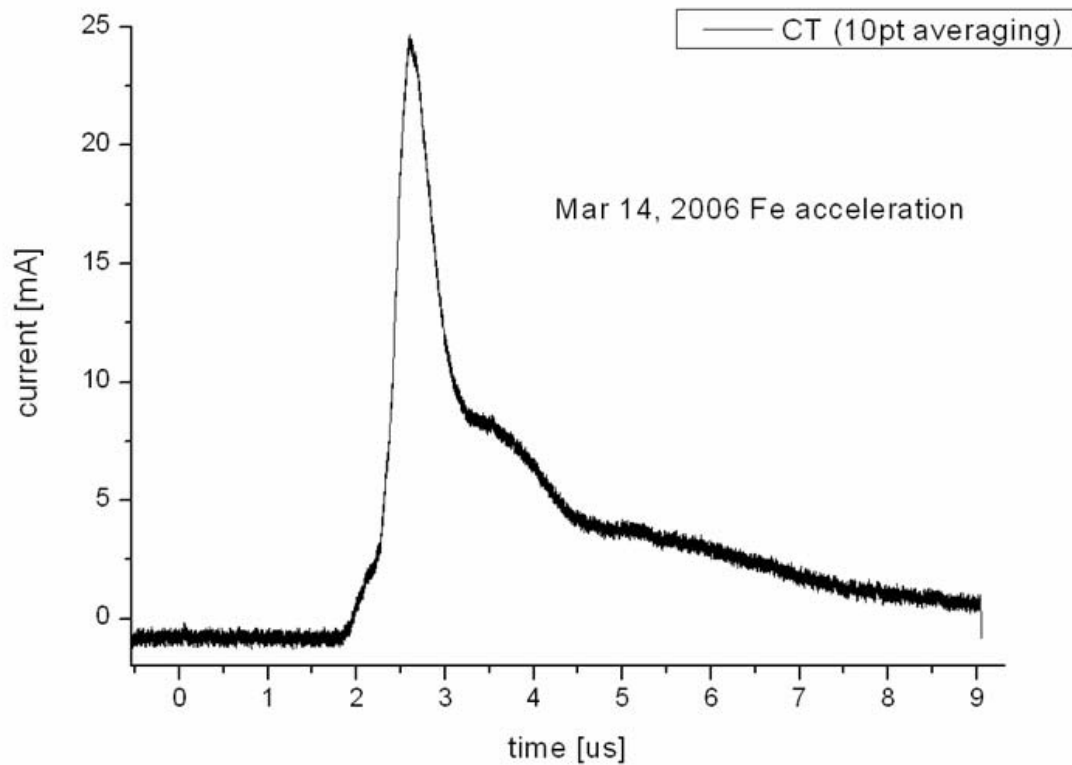
Charge state distribution

Extraction potential – 60 kV, Amplitude of RF voltage – 120 kV



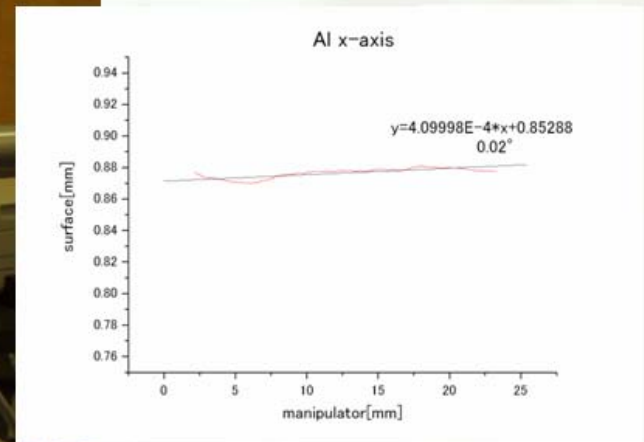
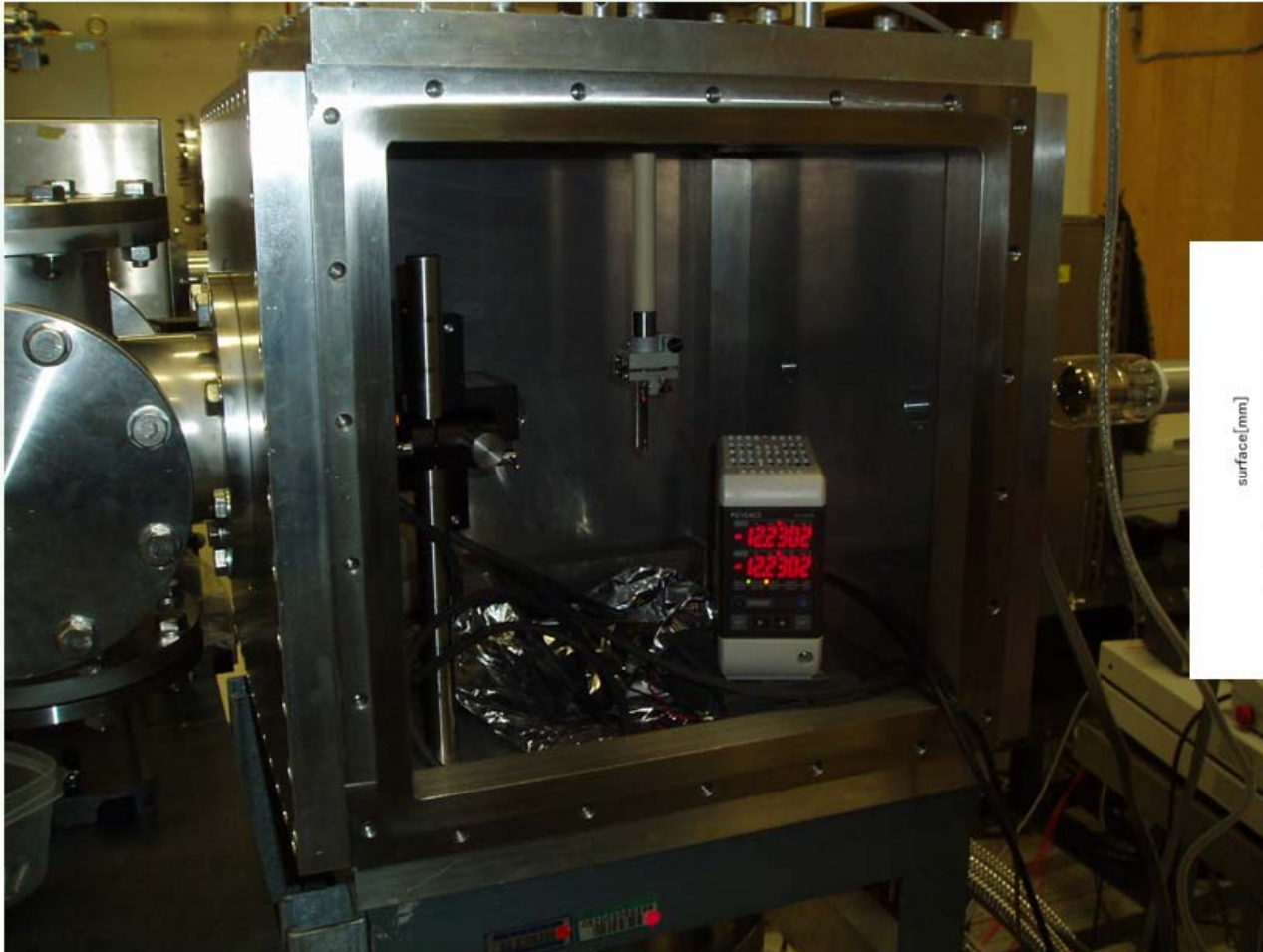
- ^{27}Al ion beam with total current up to 70 mA, $0.65 \mu\text{s}$
- $^{27}\text{Al}^{9+}$ ions occupy about 65%.

Iron with 2.3 J YAG laser



Mainly Fe¹⁶⁺ injected

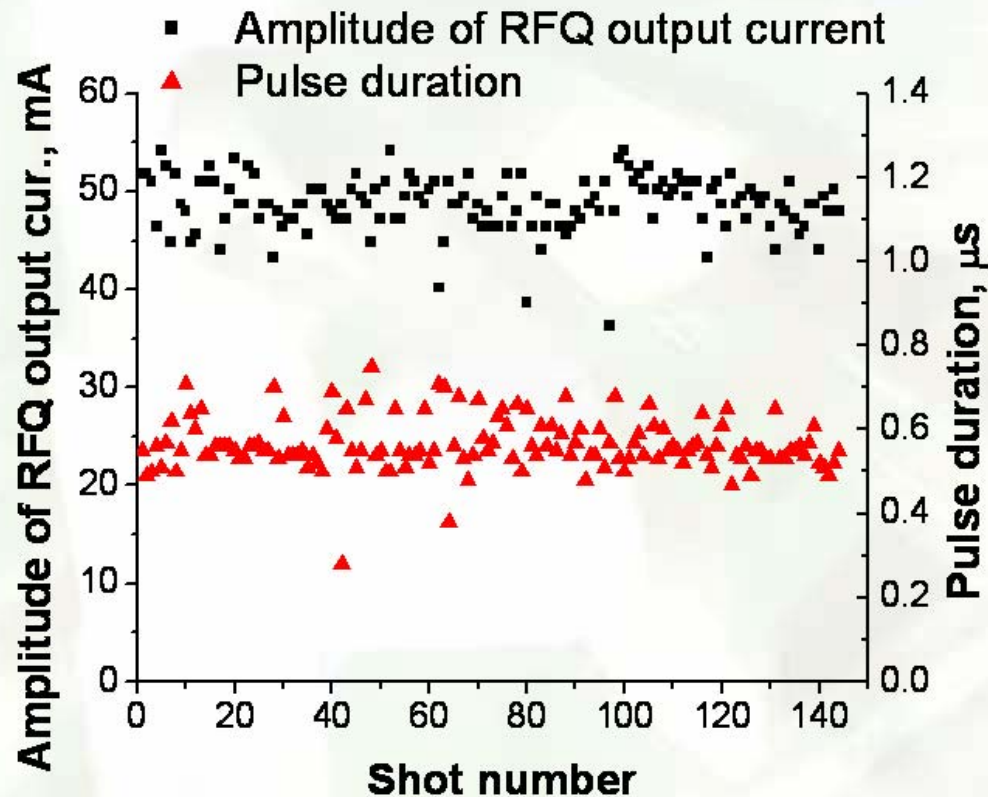
Shot-to-shot stability



- A 3D manipulator provides every new surface.
- The target position controlled within 0.1 mm accuracy.

Shot-to-shot stability

Extraction potential – 60 kV, Amplitude of RF voltage – 120 kV



$$\langle I \rangle = 49 \text{ mA} \pm 6\%$$

$$\langle \tau \rangle = 0.56 \text{ } \mu\text{s} \pm 11\%$$

Can be improved more.

Easy to get more stability on lower mass element like Carbon.

Hybrid (LIS for ECR)

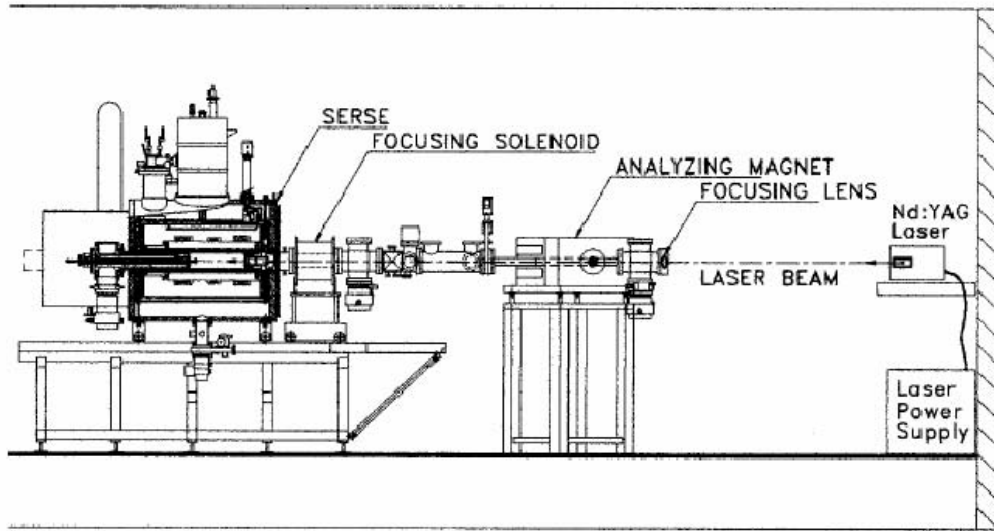
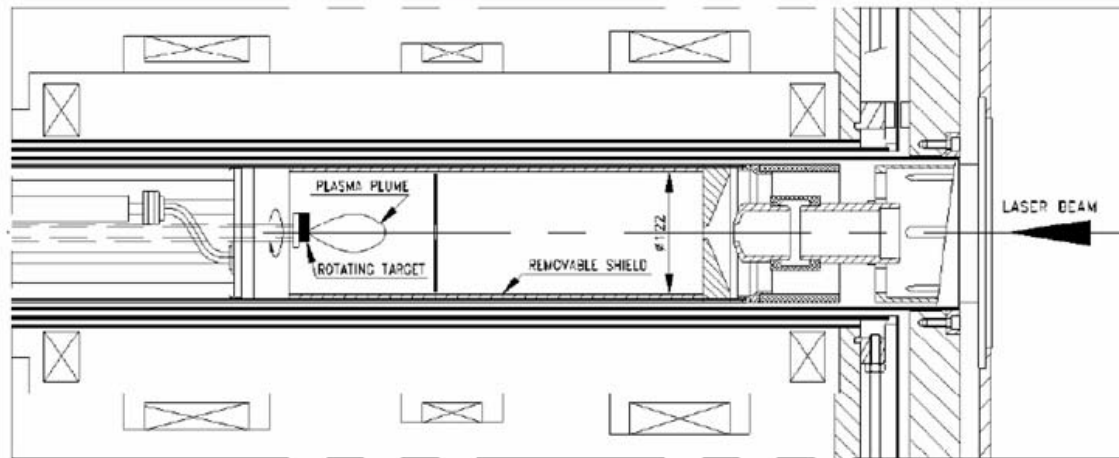


TABLE III. The best current for Ta and Au beams (** indicates the presence of the collimator above the extractor and a reduction of a factor 3 in current).

Charge state	Ta current (e μ A)	Au current (e μ A)
22	40	
23	40	
24	45	
25	50	
26	40	
27	32	
28	22	20**
29	12	17**
30	—	16**
31	8	14**
32	5	12**
33	2	—
34	0.6**	6**
35	0.3**	4.5**
36	—	3.5**
37	0.2**	—
38	0.15**	1**
40		0.4**
41		0.2**



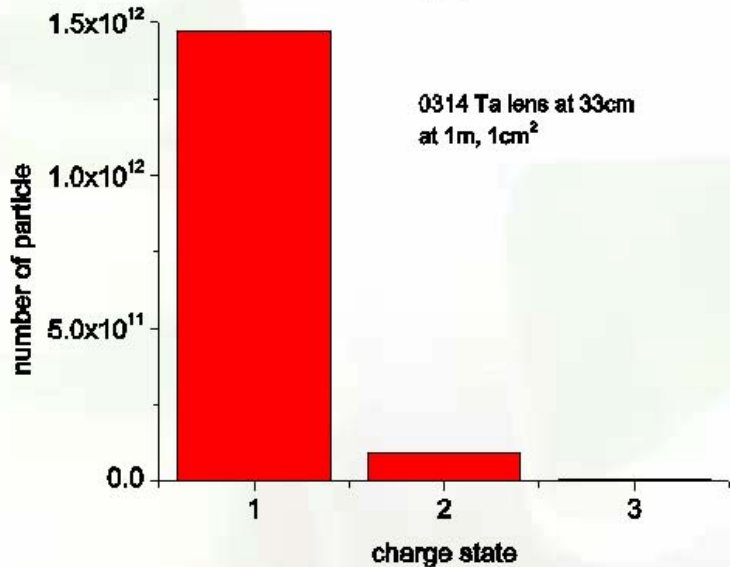
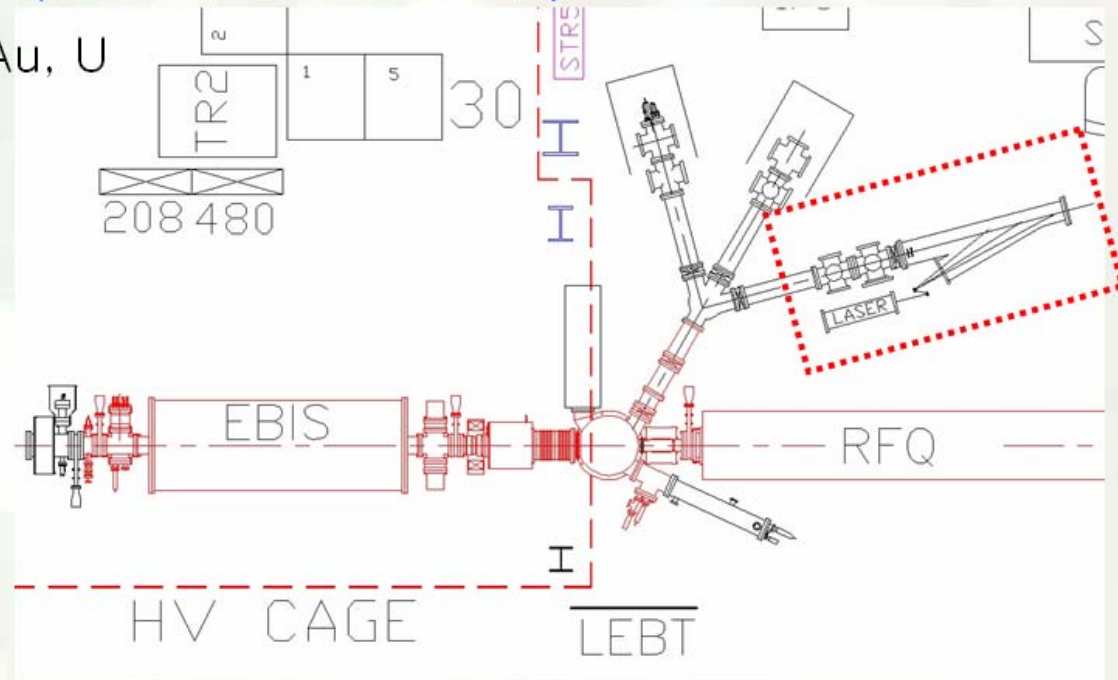
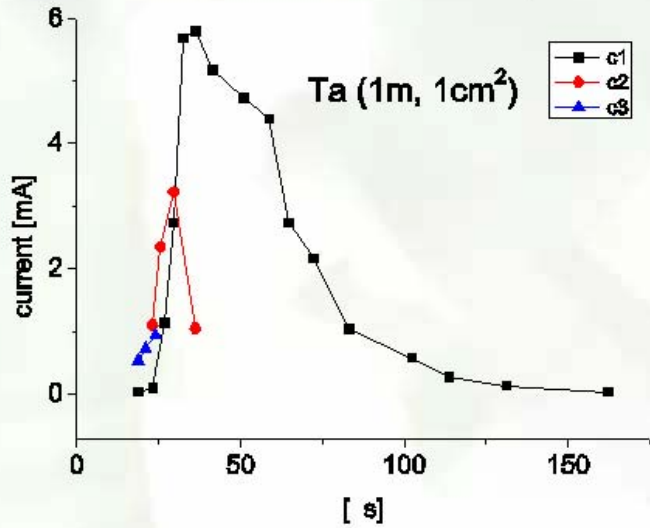
YAG laser (0.9 J/9 ns., 5×10^{10} W/cm²)
SERSE superconducting ECRIS (18 GHz)

- Initial ions seeded by a LIS for 18 GHz ECR.
- Plasma produced inside of the ECR chamber.

INFN-Laboratori Nazionali del Sud,

Hybrid (LIS for EBIS)

C, Mg, Si, S, Ca, Ti, Cr, Mn, Fe, Au, U
 10^{10} particles

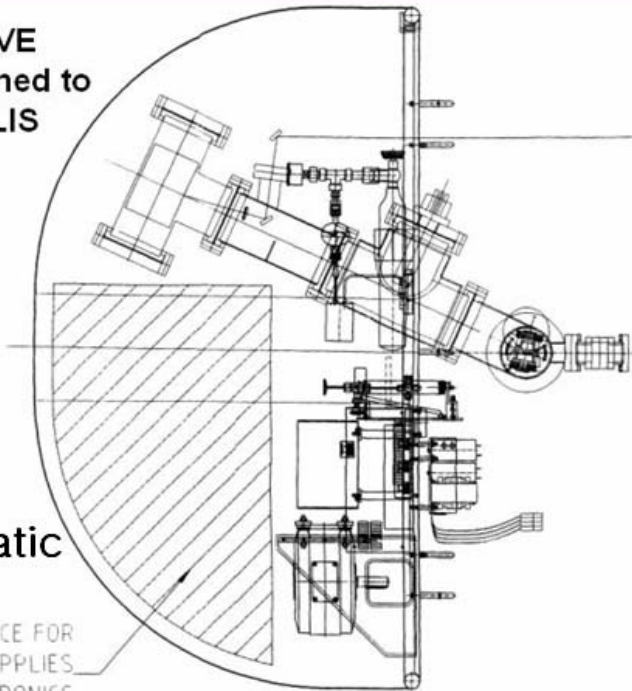


LIS for 1+ ion injection to EBIS

- mA class low charge state ion.
- 30 to 50 μ s
- Multiple targets (species switching pulse to pulse)
- Targets last very long time. (no crater)

LIS for Electrostatic accelerator

Terminal in 5 MV HVE
Singletron is designed to
accommodate the LIS



Planned schematic
 Al^{9+} to Al^{11+}

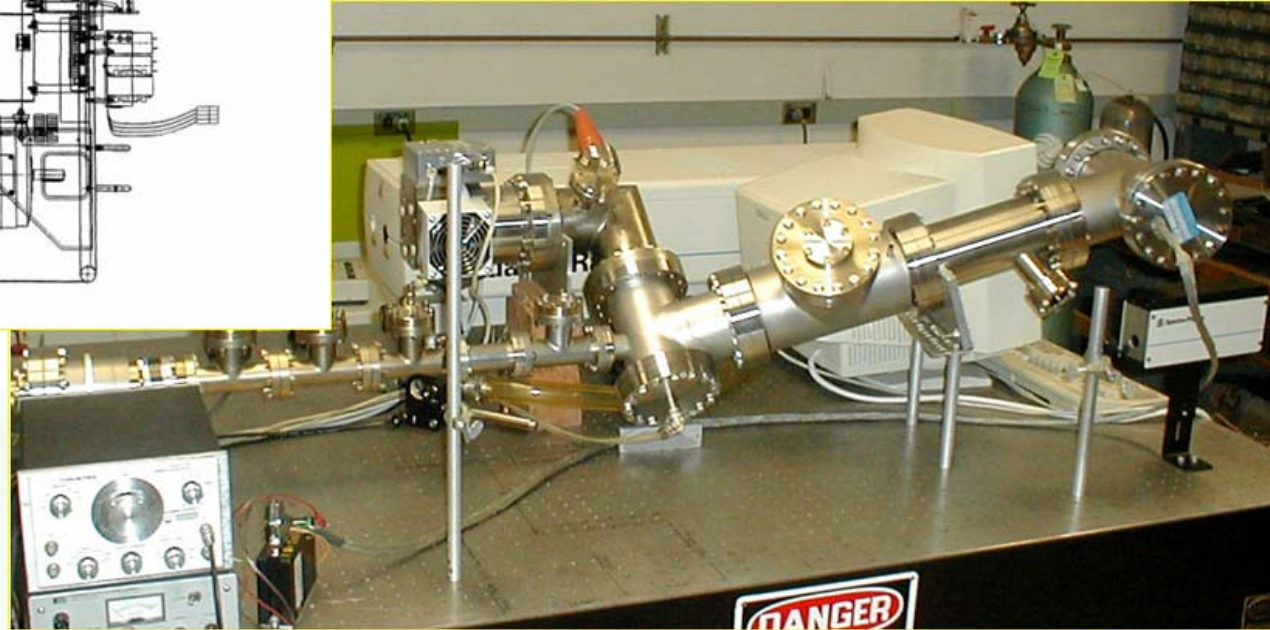
FREE SPACE FOR
LIS POWER SUPPLIES
& ELECTRONICS

RARAF, Columbia University
Micro-beam for the Biology

- Laser provides ionization energy to a high voltage terminal.
- 100 Hz operation was verified.

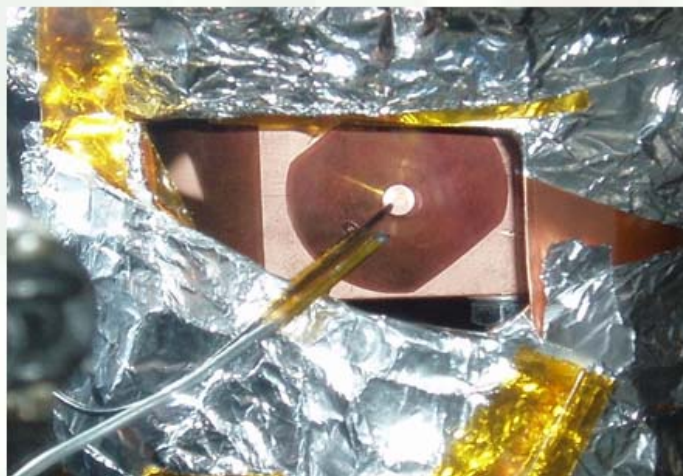
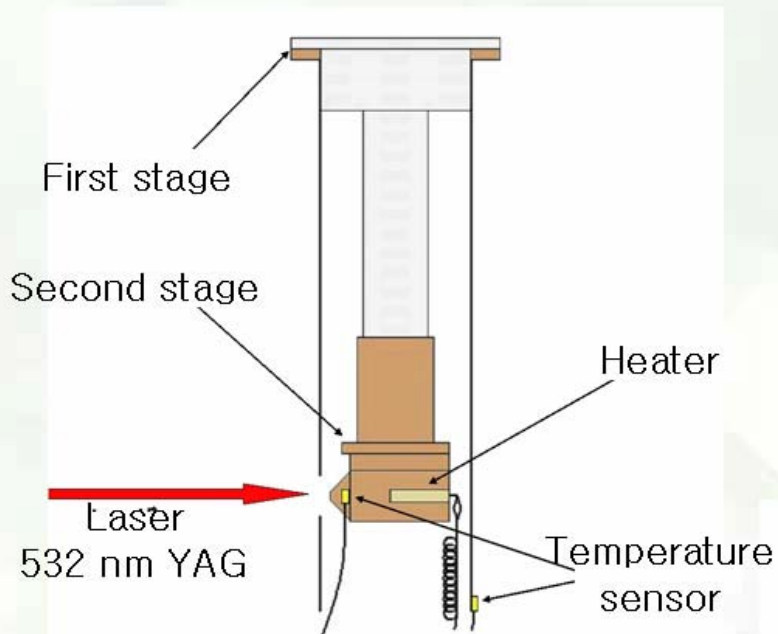
Quanta-Ray LAB-190-100
Nd:YAG

(100 Hz-325 mJ/pulse, 10 ns)

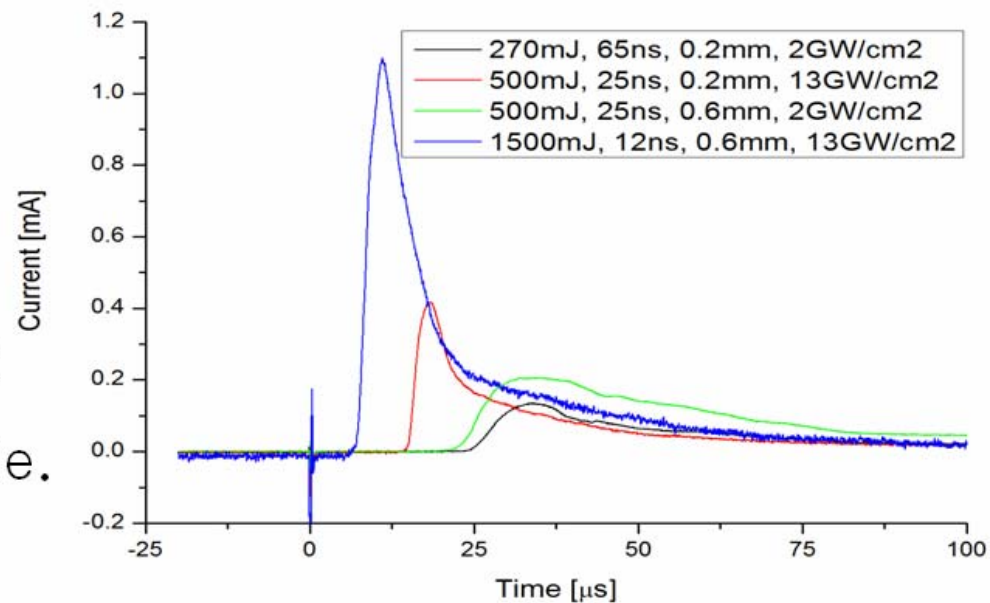


At Columbia University's Radiological Research Accelerator Facility (RARAF), a single-particle single-cell microbeam is used to study fundamental cellular response to irradiation.

Cryo target for LIS



Frozen Ne as a laser target
All gases except He applicable.



Summary

- LIS can provide pulsed highly charged intense heavy ions.
- Commercially available lasers provide high charge and high current up to Ag.
- Short pulse laser? Possibilities of high charge ions from heavy species.
- DPIS is effective to provide intense current and is simple.

Carbon : 60 mA (peak, C⁴⁺ 60 %)

C⁶⁺ : 17 mA

Aluminium : 70 mA (peak, Al⁹⁺ 65 %)

- Good stability can be achieved.
- LIS could provide primary beams for ECR and EBIS.
- LIS is also good for low charge, heavy mass and long pulse beam.
- High repetition rate matches future accelerators.
- Gas species can be used as targets.







The authors thank to colleagues at :

T.I.Tech

RIKEN

JAEA

Kyusyu U.

AEC

NIRS

ITEP

IMP

Frankfurt U.

CERN

PALS

INFN

BNL

Columbia U.

Thank you for your attention.

